

2359-19

**Joint ICTP-IAEA Workshop on Physics of Radiation Effect and its Simulation
for Non-Metallic Condensed Matter**

13 - 24 August 2012

**Fundamental aspects of radiation damage of nonmetallic materials:
Microstructural evolution**

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Fundamental aspects of radiation damage of nonmetallic materials: Microstructural evolution

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**IAEA/ICTP School on Physics of Radiation Effects and
its Simulation for Non-metallic Condensed Matter**

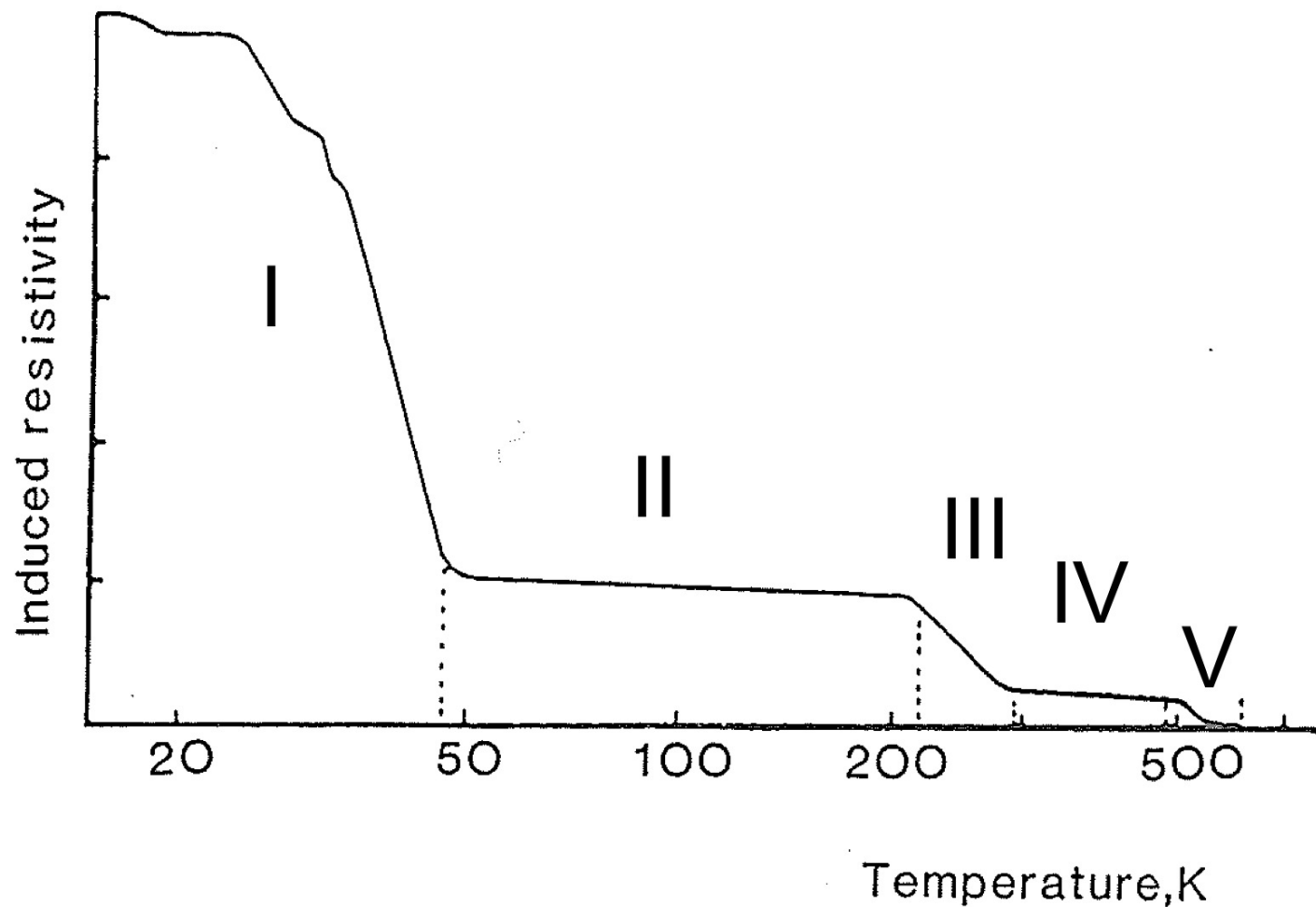
Trieste, Italy

August 13-24, 2012

Outline

- Temperature dependence of microstructural evolution
 - Important regimes include onset temperatures for interstitial and vacancy defects
- Dose dependence of microstructural evolution
- Effect of irradiation spectrum
 - Primary knock-on atom effects
 - Ionizing radiation effects
 - Swift heavy ion effects (brief introduction)

Electrical resistivity defect recovery stages in copper after electron irradiation at 4 K



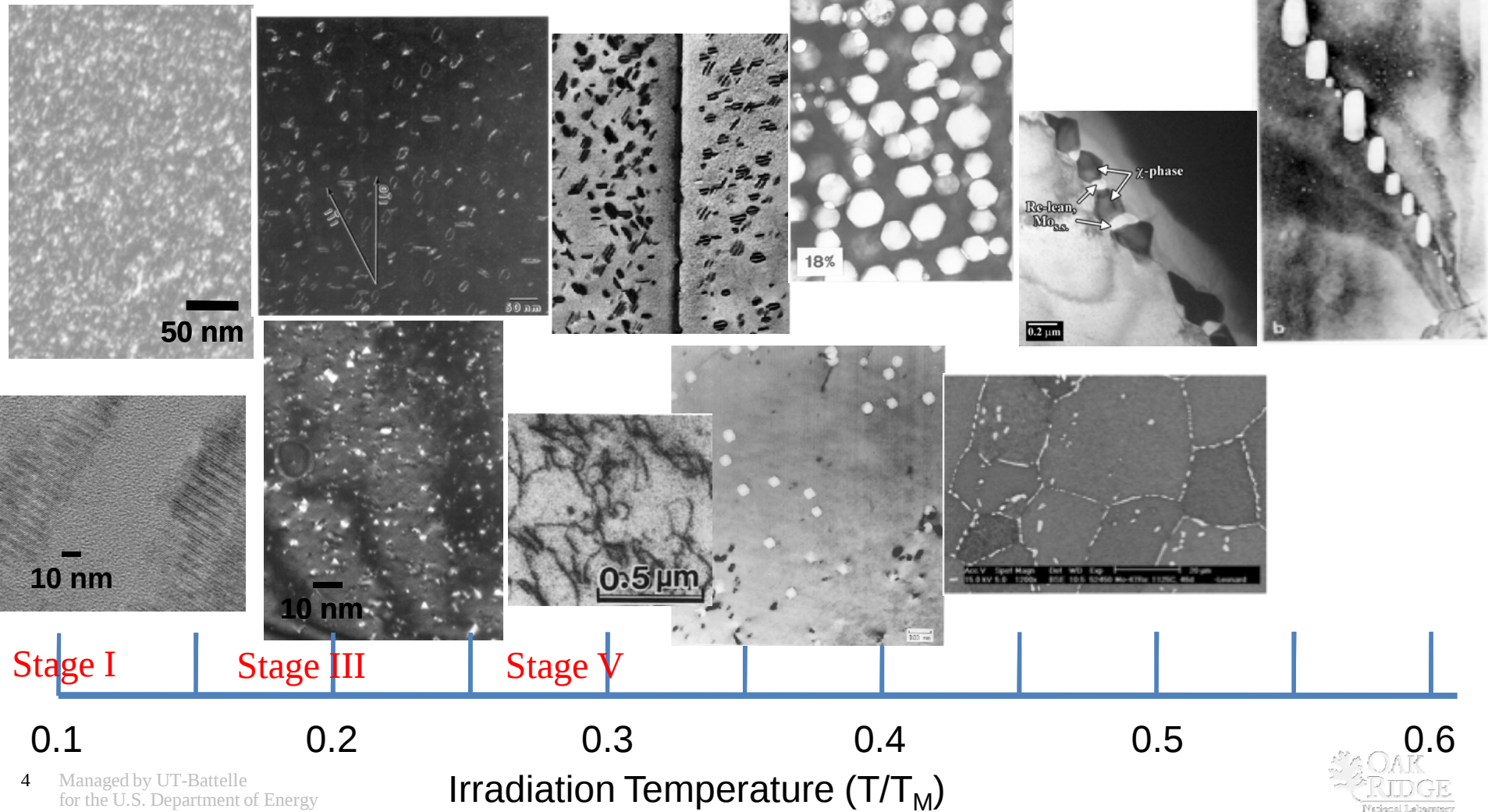
Overview of Defect Microstructures in Irradiated Materials

Dislocation loops

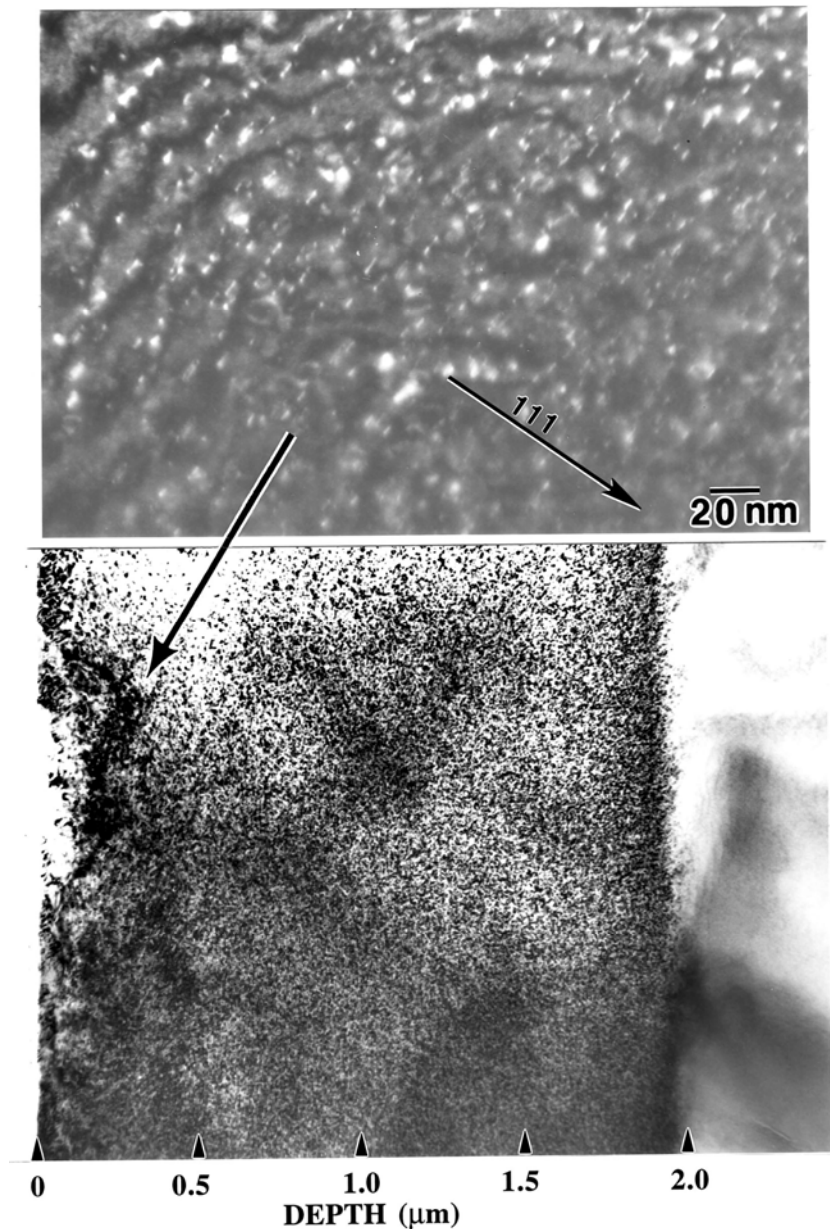
Voids, precipitates, solute segregation

Grain boundary helium cavities

Amorphization



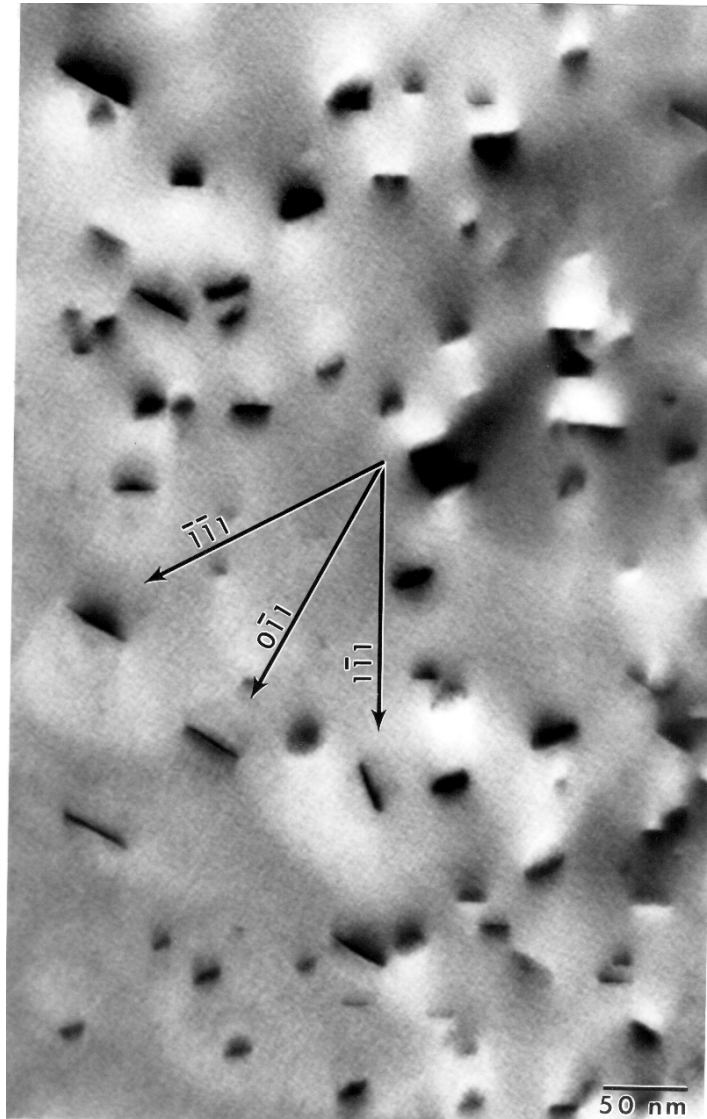
Microstructure of MgAl_2O_4 following 4 MeV Ar ion irradiation to 5 dpa at 200 K



S.J. Zinkle and G.P. Pells, J. Nucl. Mater. 253 (1998) 120

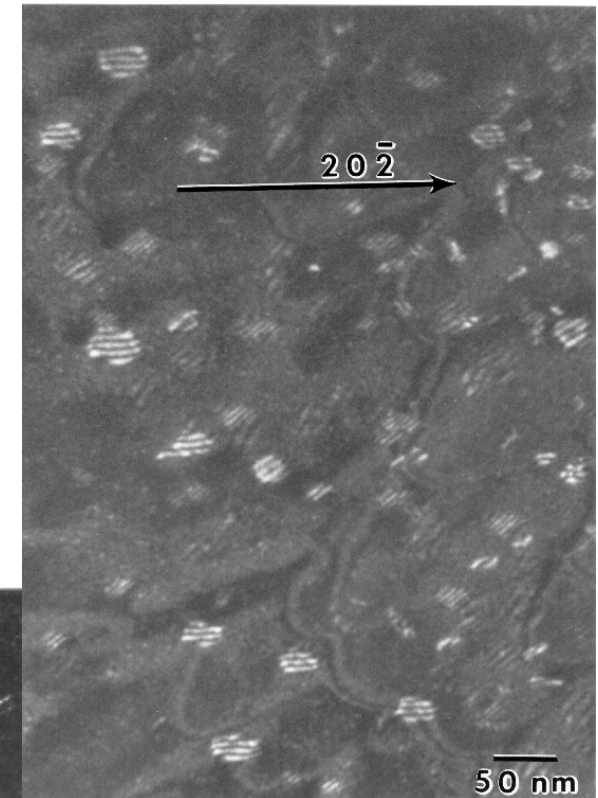
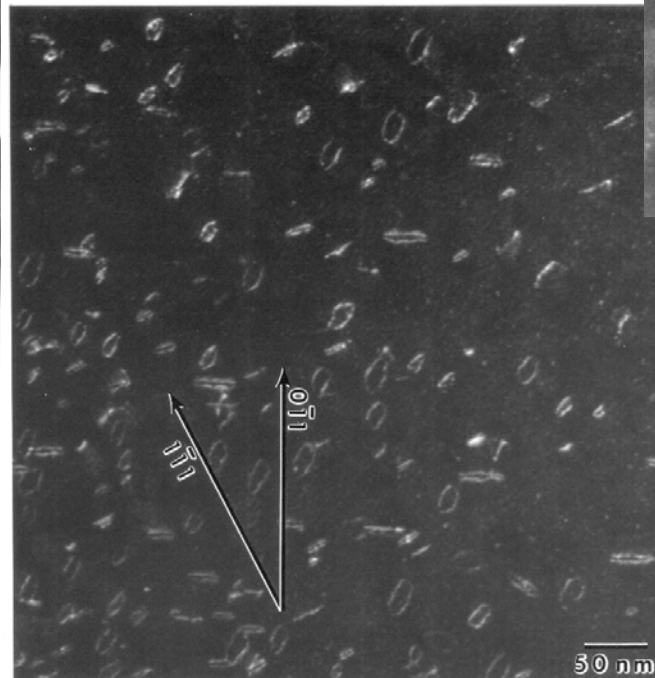
Quantification of dislocation loops in irradiated materials

Habit plane determination



for the U.S. Department of Energy

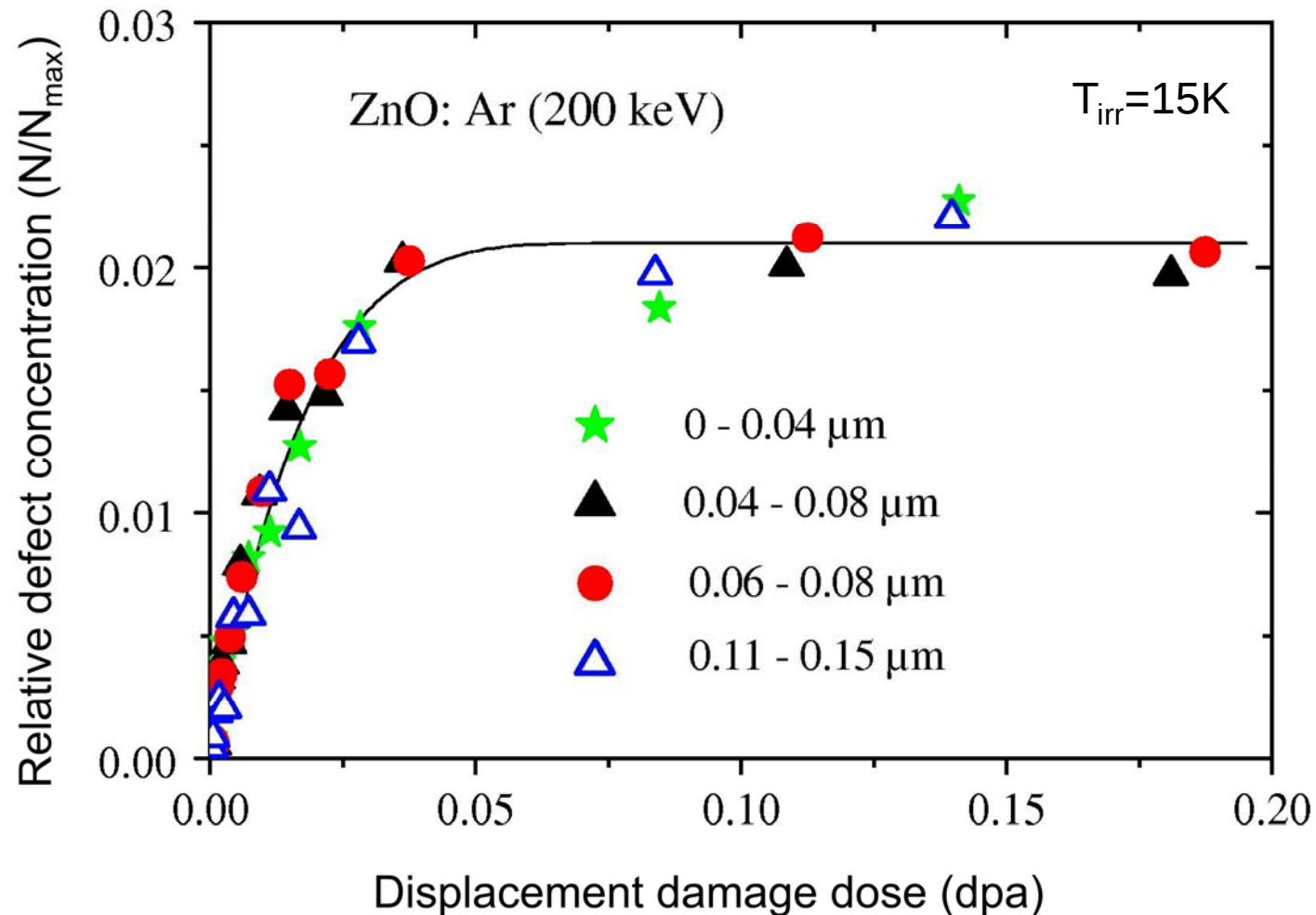
Displacement vector evaluation



S.J. Zinkle



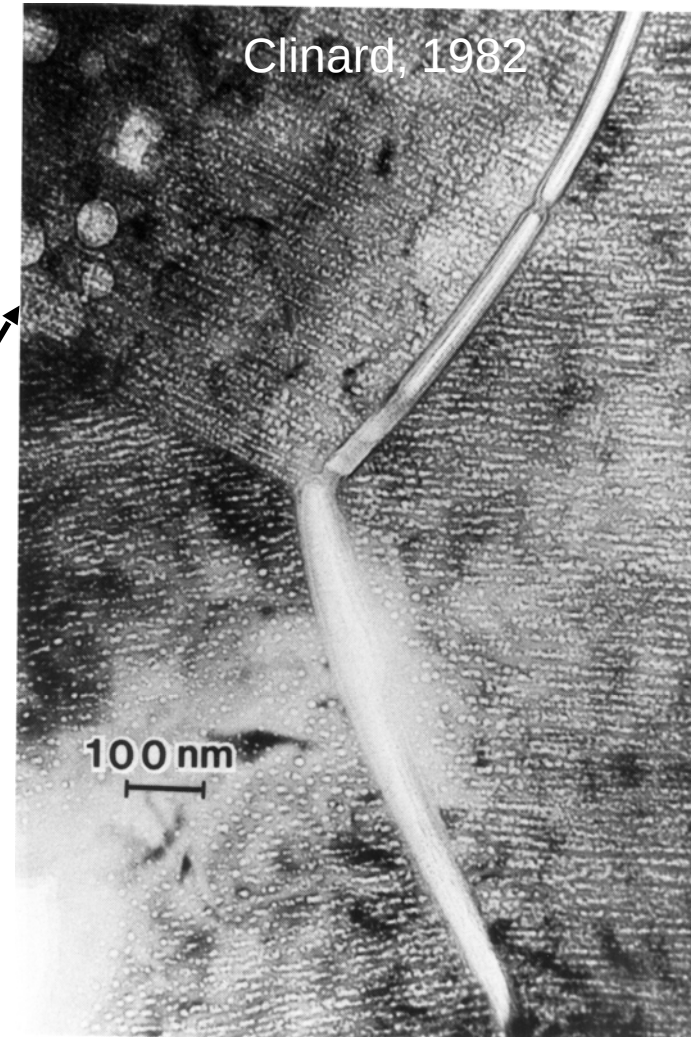
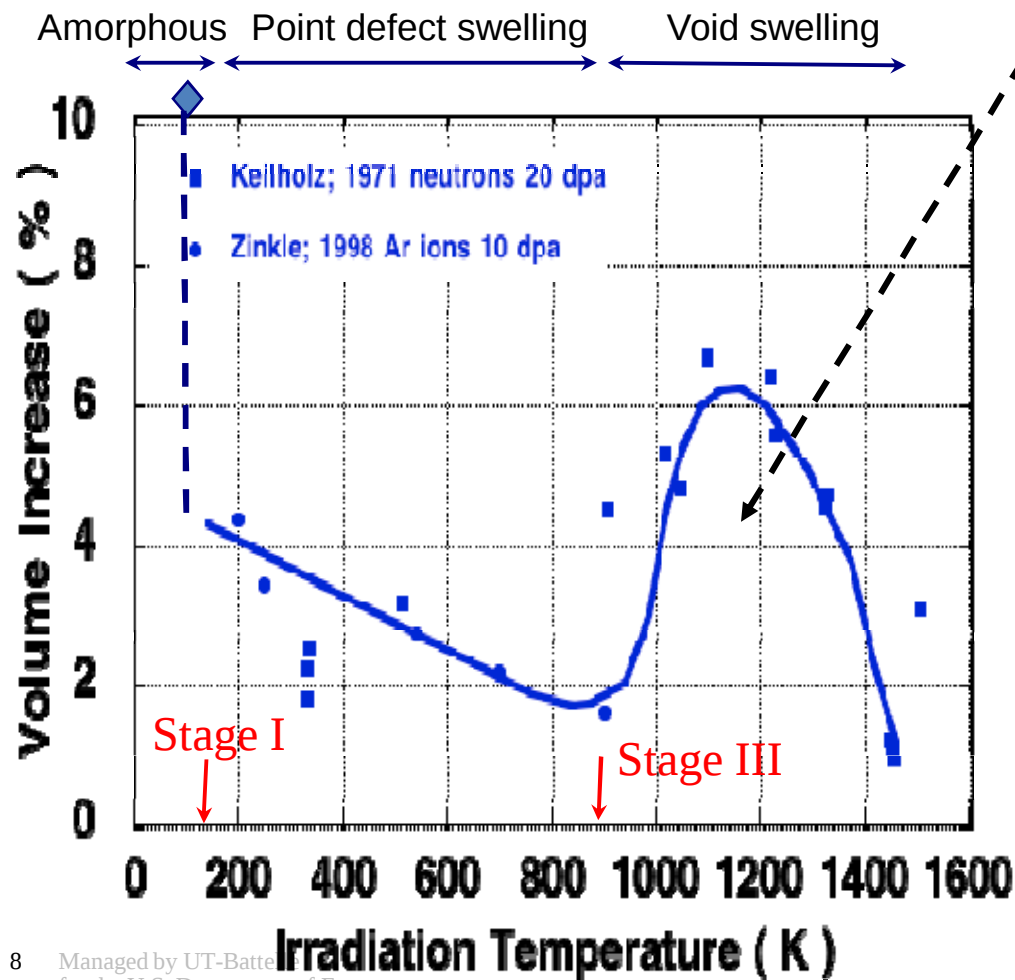
Defect concentration at four depths in ZnO irradiated with 200 keV Ar ions at 15K (Rutherford Backscattering Spectrometry)



Note: defect saturation achieved for a dose <0.05 dpa at low T_{irr} (immobile defects)

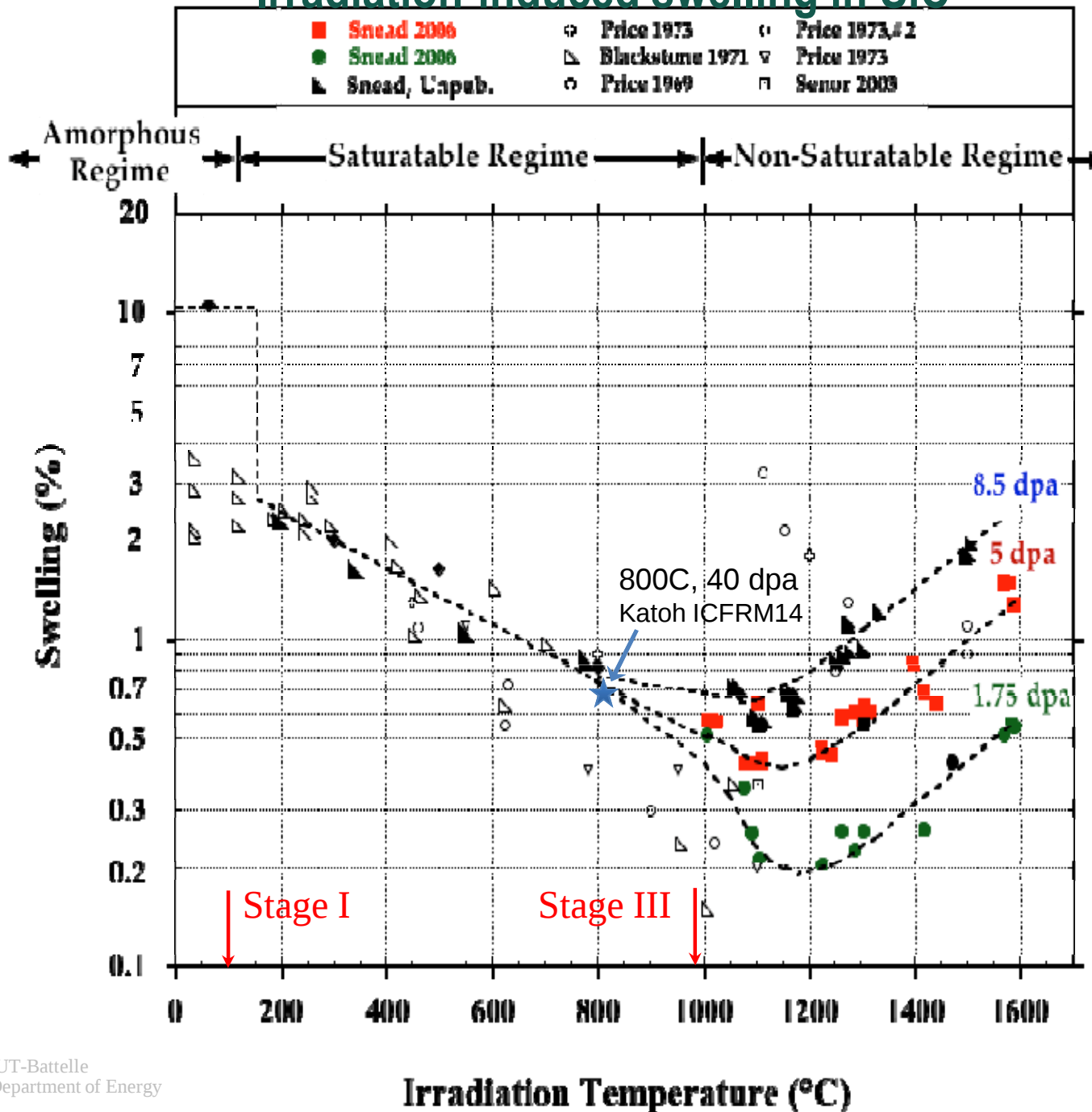
Overview of swelling regimes in Al_2O_3

- 3 distinct swelling regimes are observed in irradiated Al_2O_3

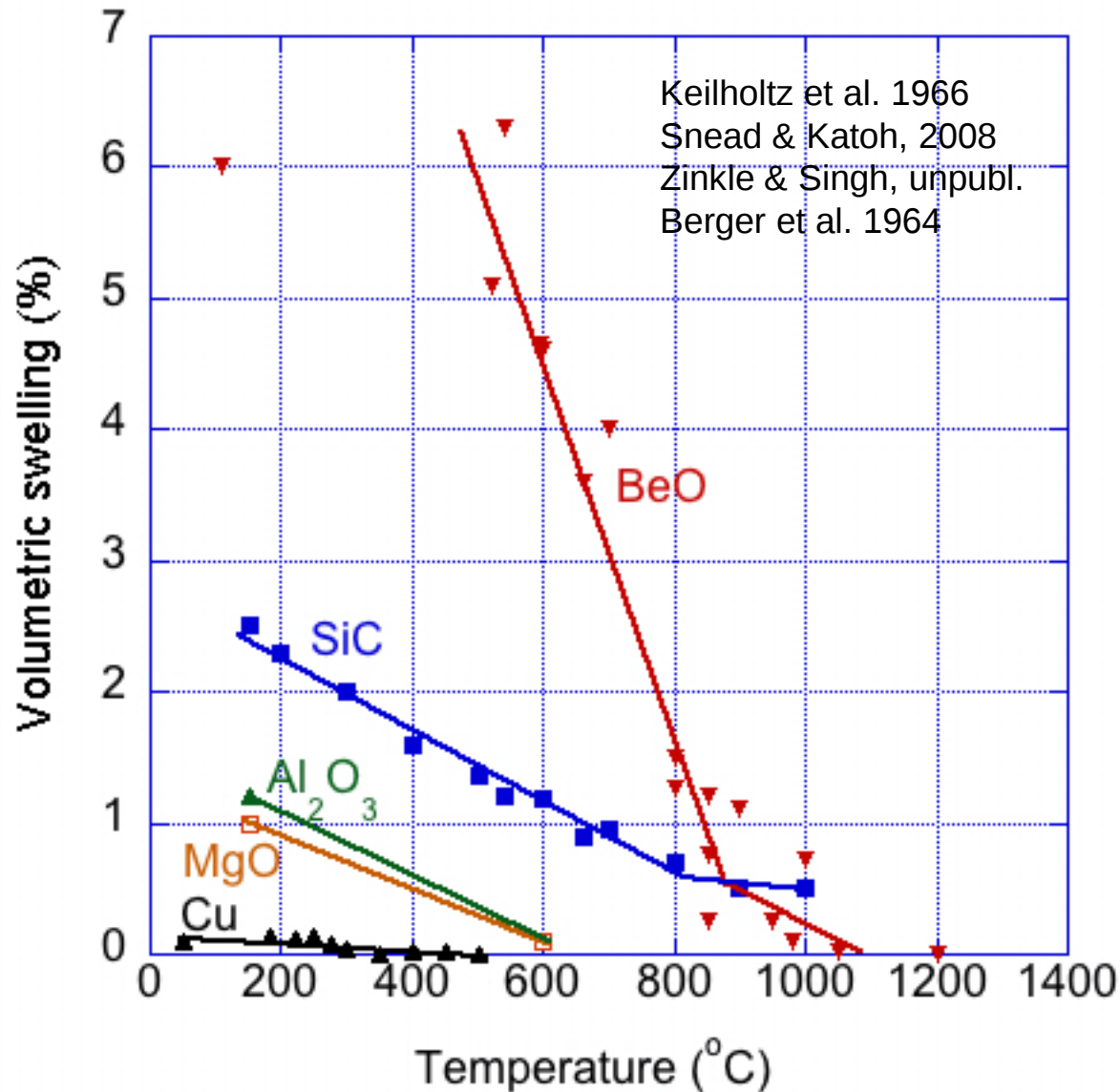


- Activation Energies:
 - Al vacancy; 1.8-2.1 eV
 - O vacancy; 1.8-2 eV
 - Al, O interstitial; 0.2-0.8 eV

Irradiation-induced swelling in SiC



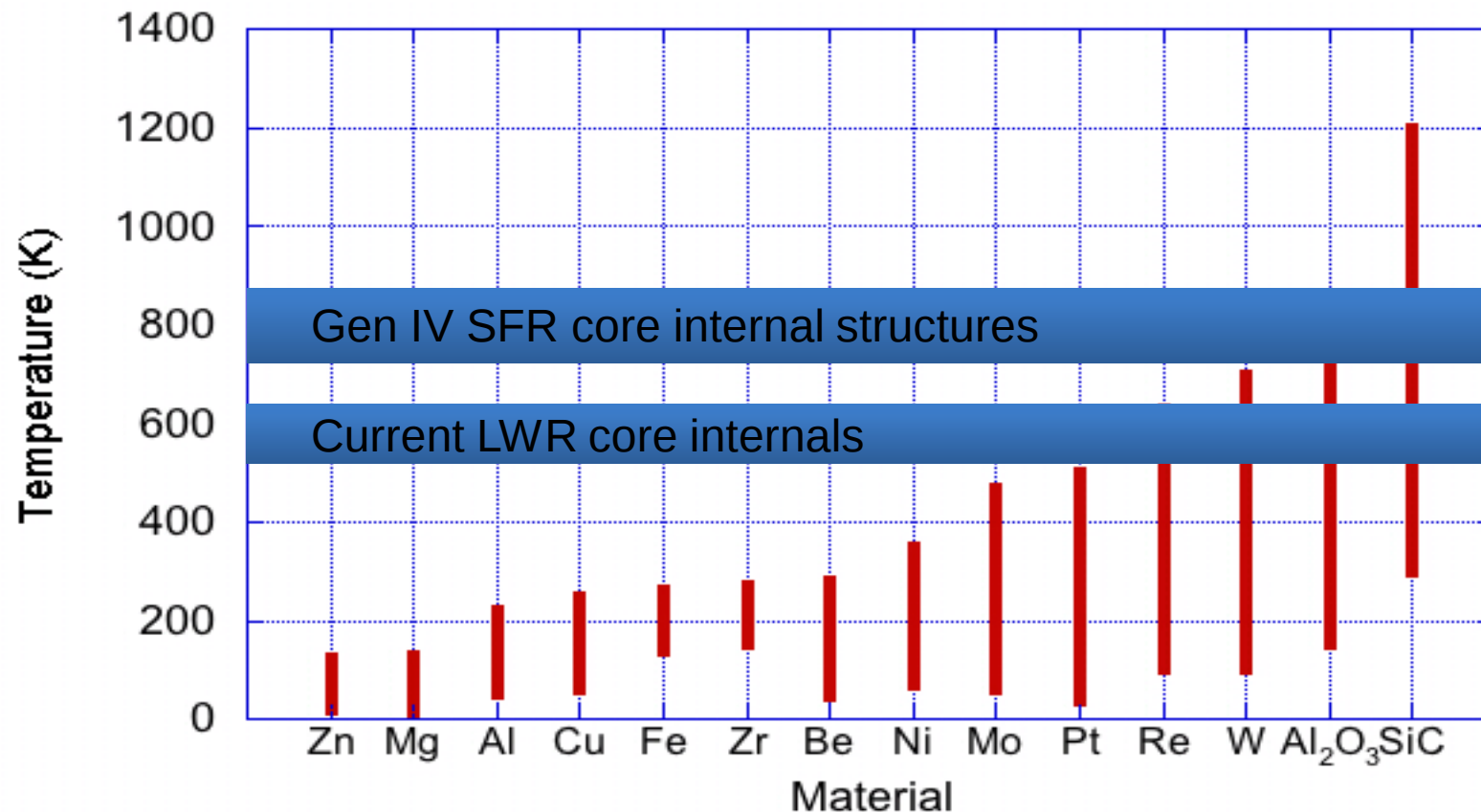
Comparison of point defect swelling behavior in irradiated metals and ceramics



- Large variation in magnitude of point defect swelling in materials
- Metals typically have point defect swelling values near 0.1% (Al, Cu, Ag, Au), compared to 1-5% for ceramics
 - Implies shorter point defect recombination radii or reduced barriers for recombination in metals versus ceramics

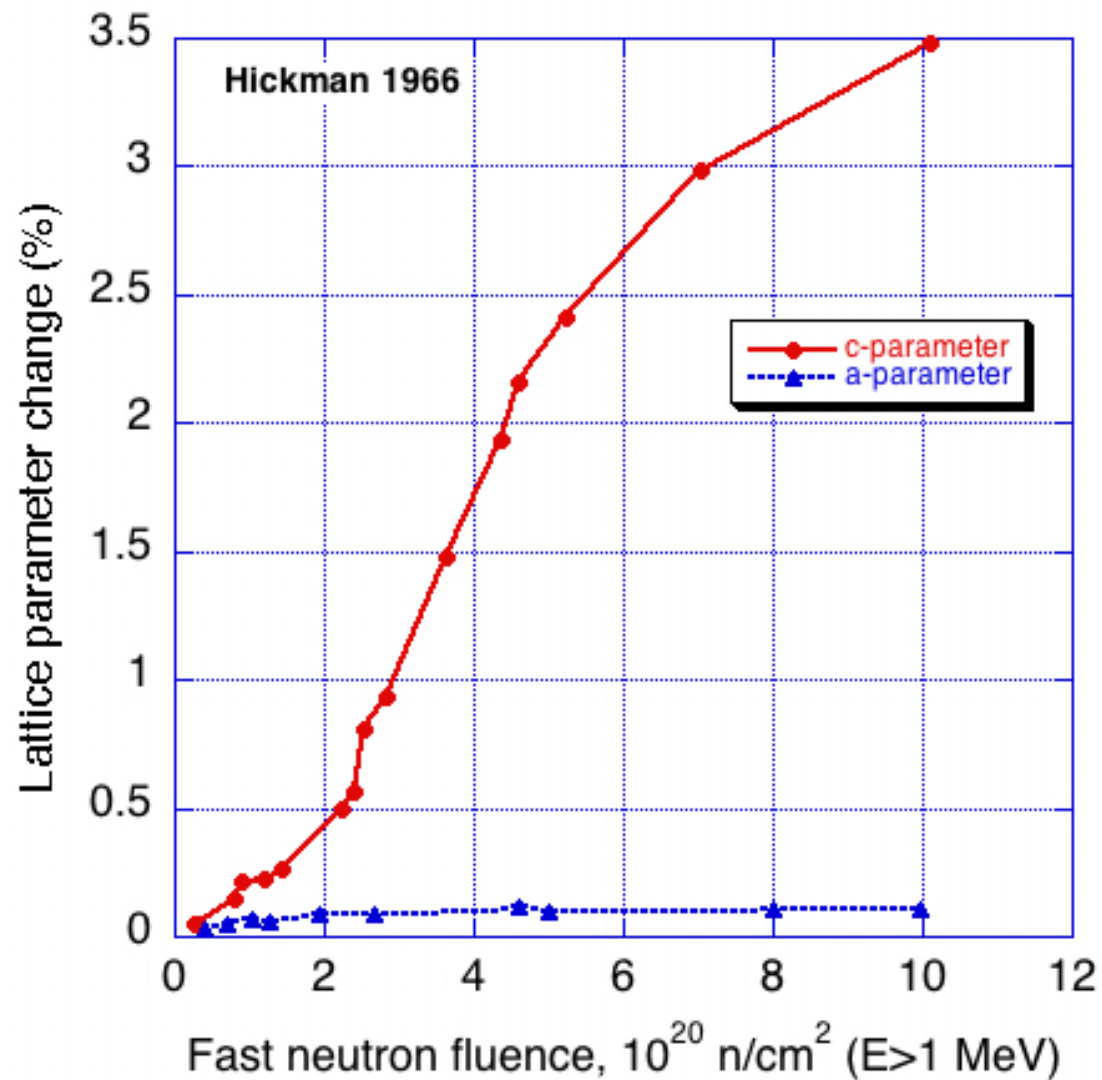
One strategy for radiation resistance: Immobile defects

- Defect accumulation is limited if one or more defect types are immobile
 - Utilize materials with negligible point defect mobility at desired operating temperatures
 - A key potential consequence (particularly in ordered alloys and ceramics) is amorphization, with accompanying significant volumetric and property changes

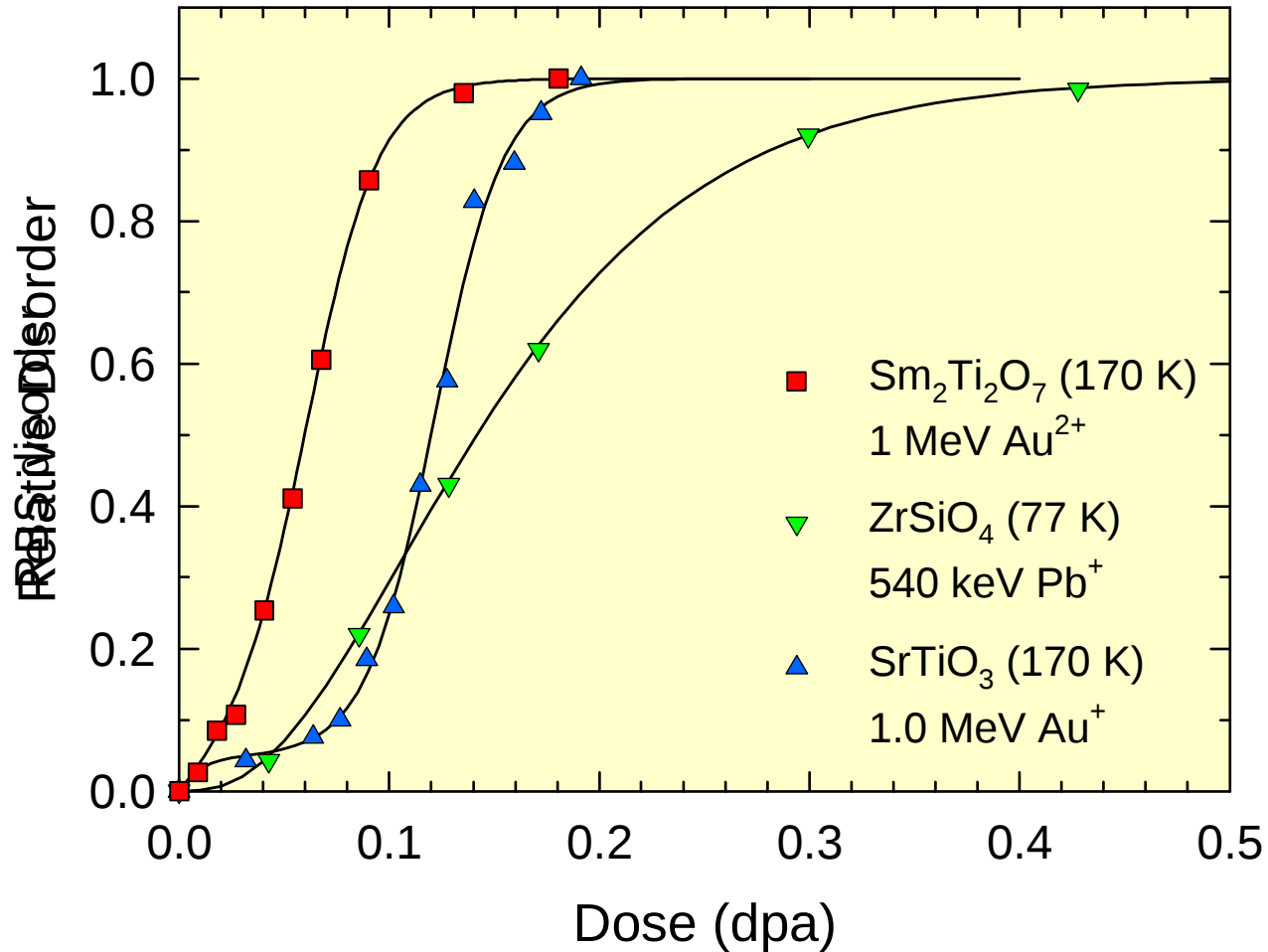


- Regime with intrinsically high point defect recombination typically occurs at too low of temperatures for power generation applications (except SiC and possibly Al₂O₃, W, Re)

Effect of fission neutron irradiation near 75°C on the lattice parameters of BeO



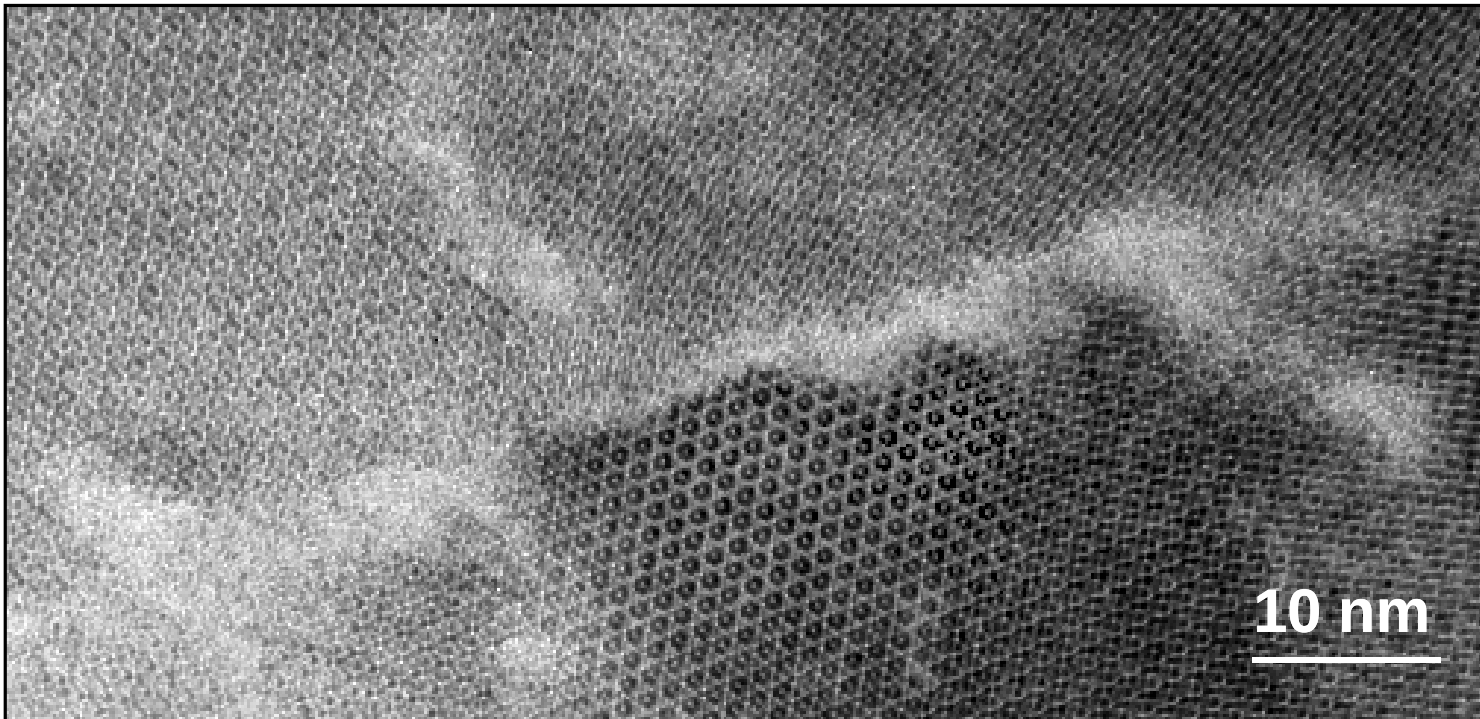
Crystalline Oxides: Dose Dependence



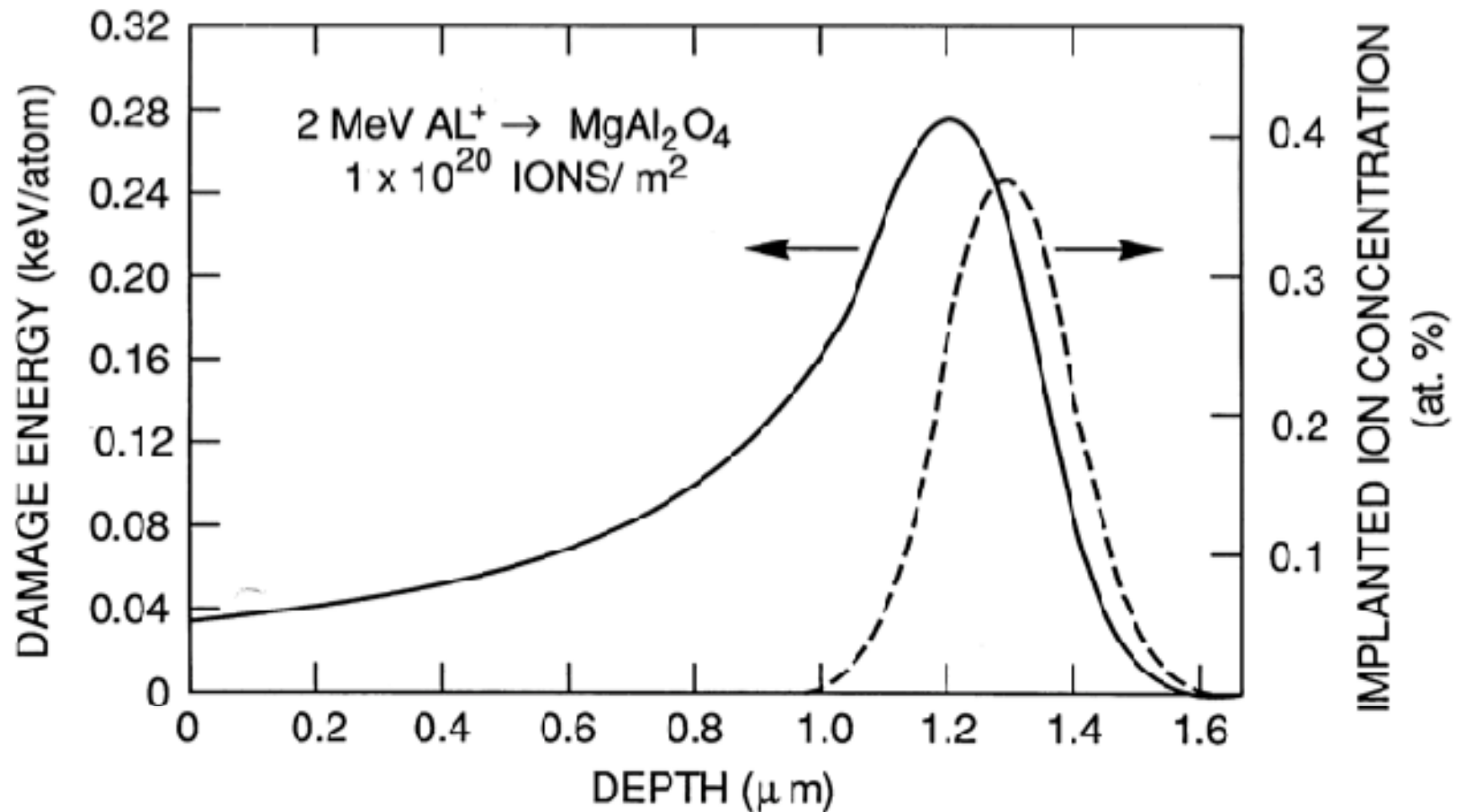
Amorphization occurs by several mechanisms or pathways

Direct-Impact Amorphization in Ceramics

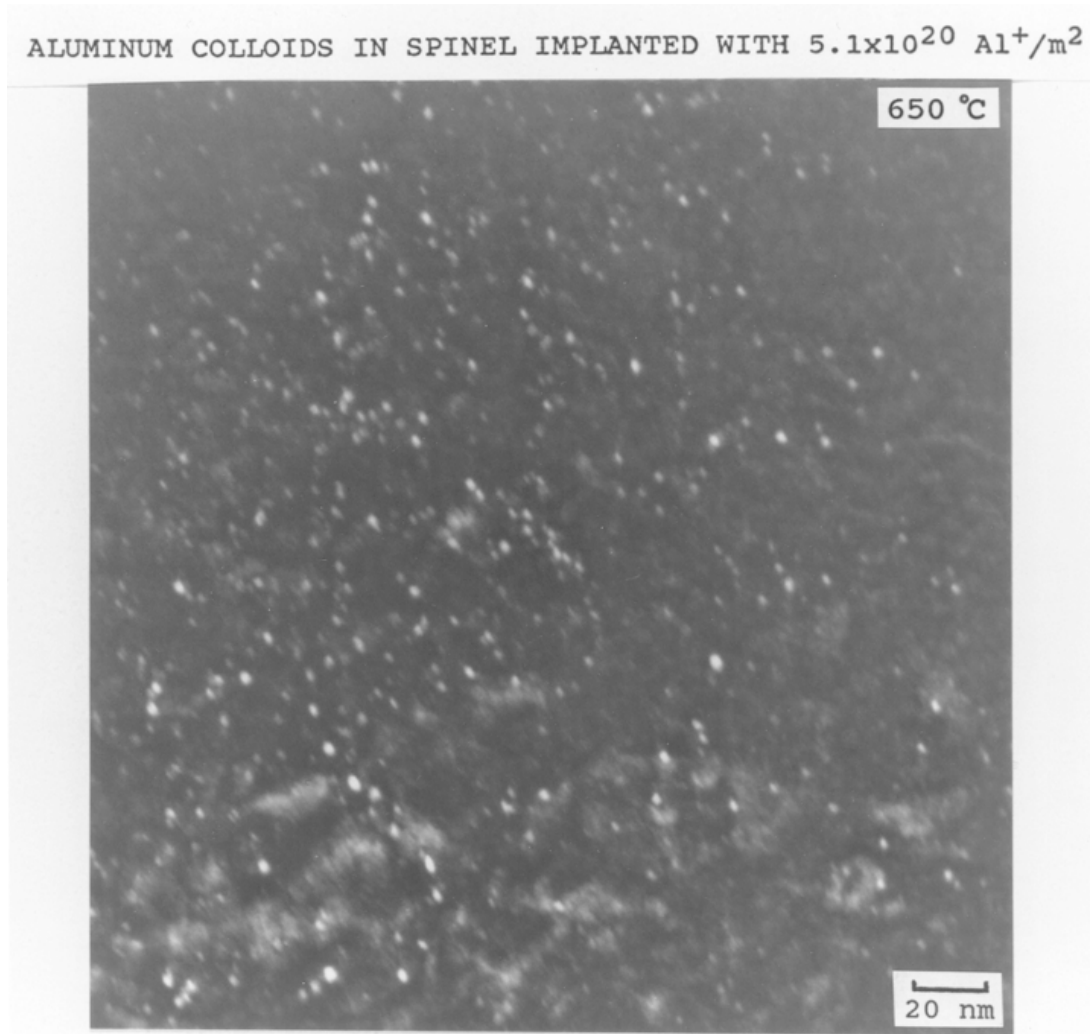
Amorphization Along 800 keV Kr⁺ Ion Track in Ca₂La₈(SiO₄)₆O₂



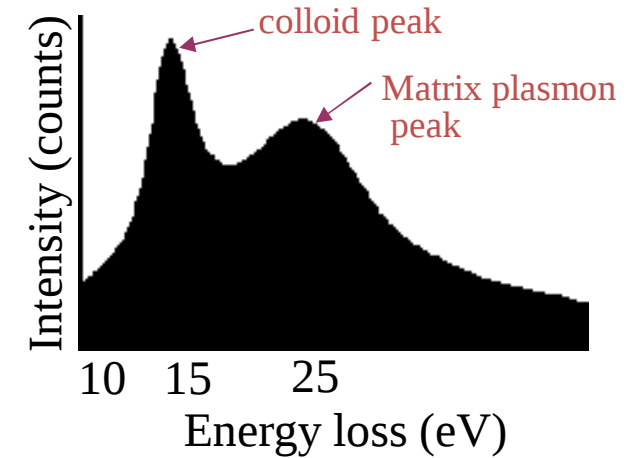
Calculated depth-dependent damage energy and implanted ion profiles for 2 MeV Al ion irradiated MgAl_2O_4



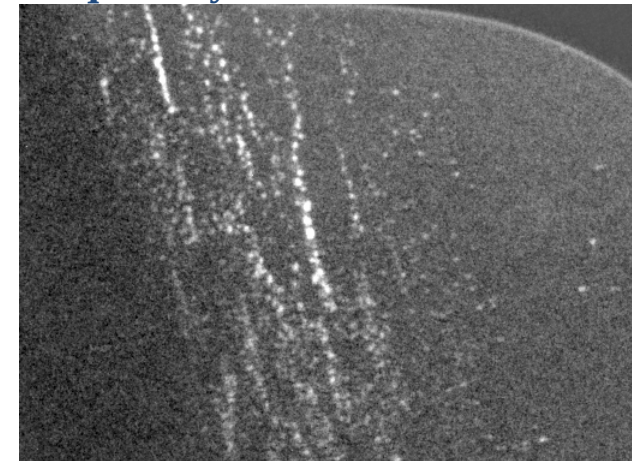
Colloidal metal nanoclusters can be created in MgAl_2O_4



PEELS spectrum for implanted MgAl_2O_4

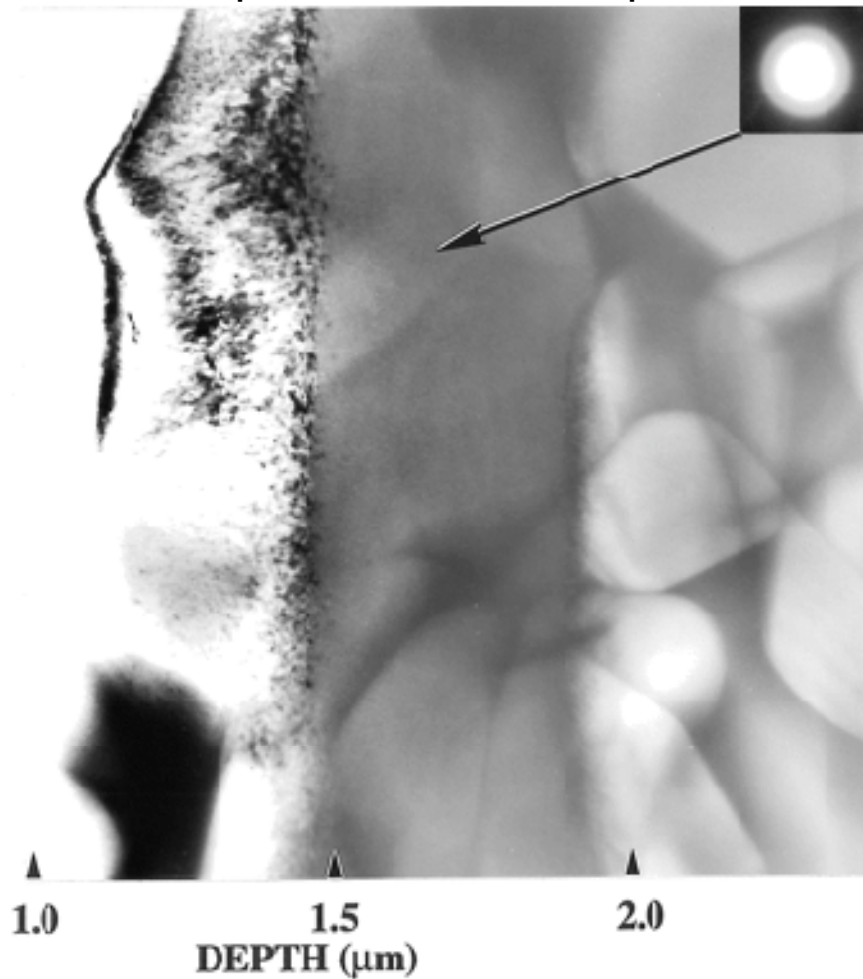


Energy-filtered TEM used to quantify colloid distribution

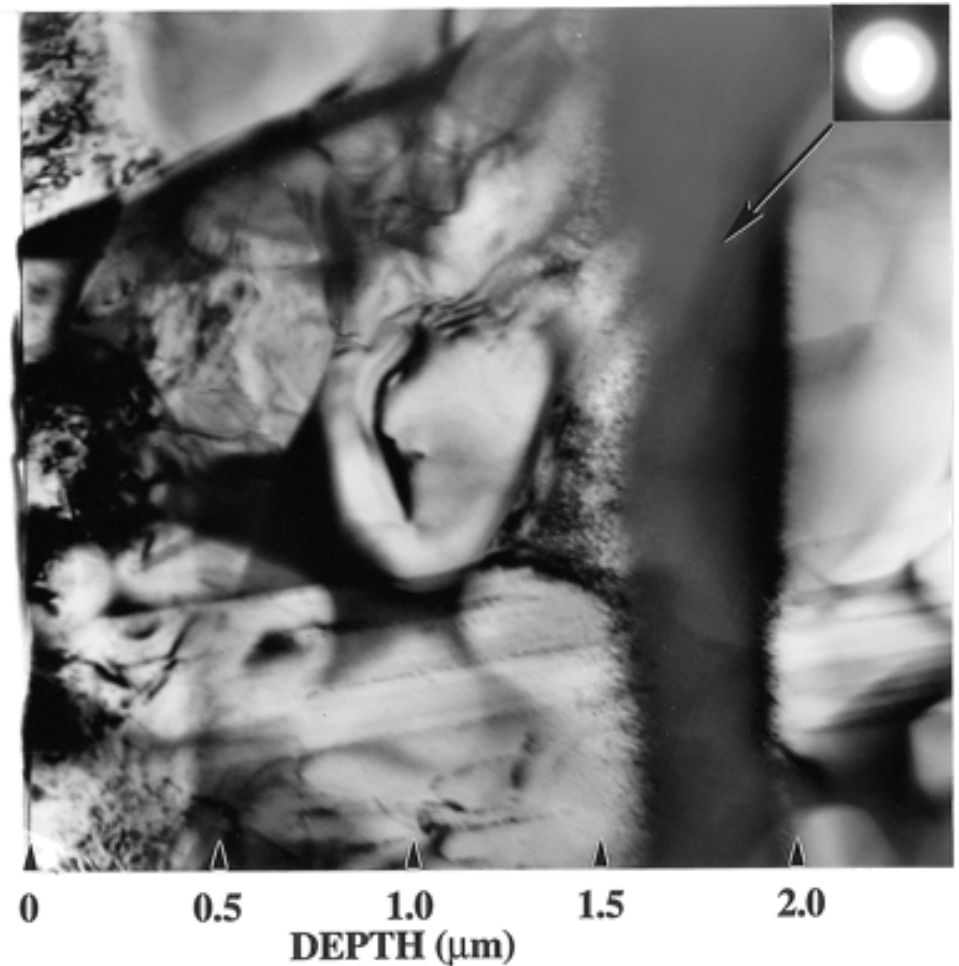


Implanted ion stabilized amorphous band in Si_3N_4 after 3.6 MeV Fe ion irradiation at 300 K

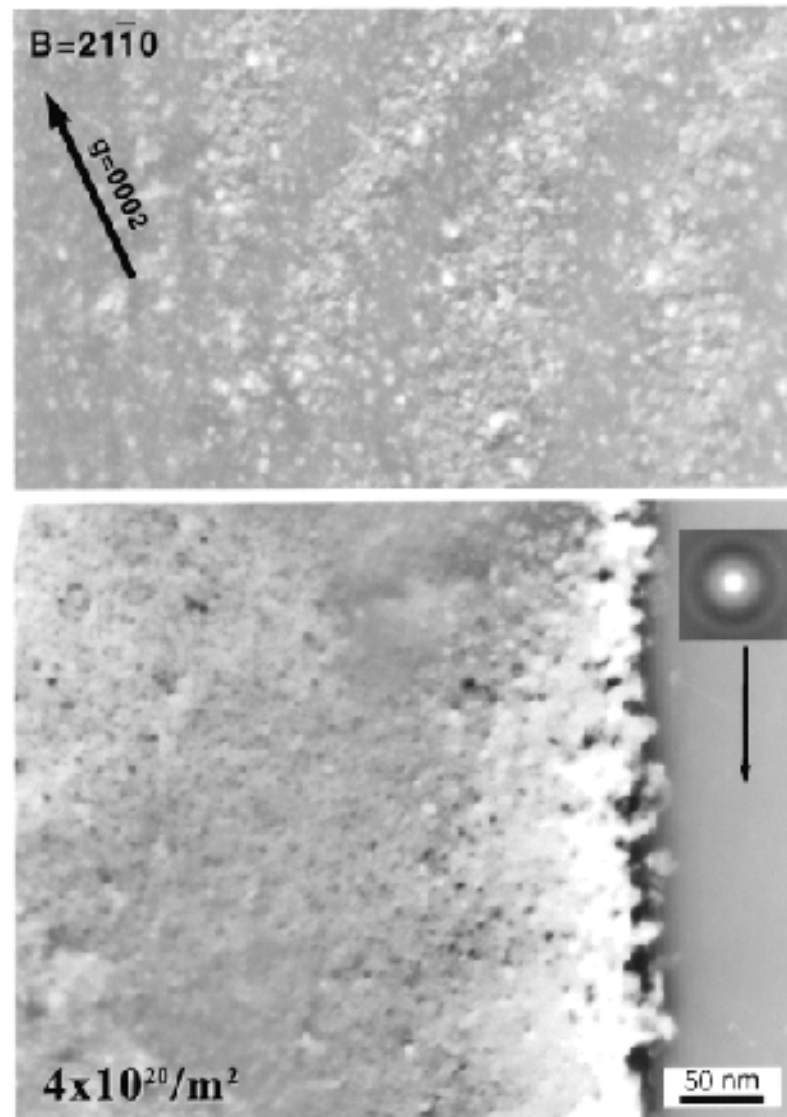
$0.22 \times 10^{20} \text{ Fe/m}^2$
1.3 dpa, 0.1 at.% Fe at peak



$1.1 \times 10^{20} \text{ Fe/m}^2$
7 dpa, 0.4 at.% Fe at peak; 5 dpa at 1.5 μm



Defect clusters in AlN after 2 MeV Si ion irradiation to $4 \times 10^{20}/\text{m}^2$ at 78 K



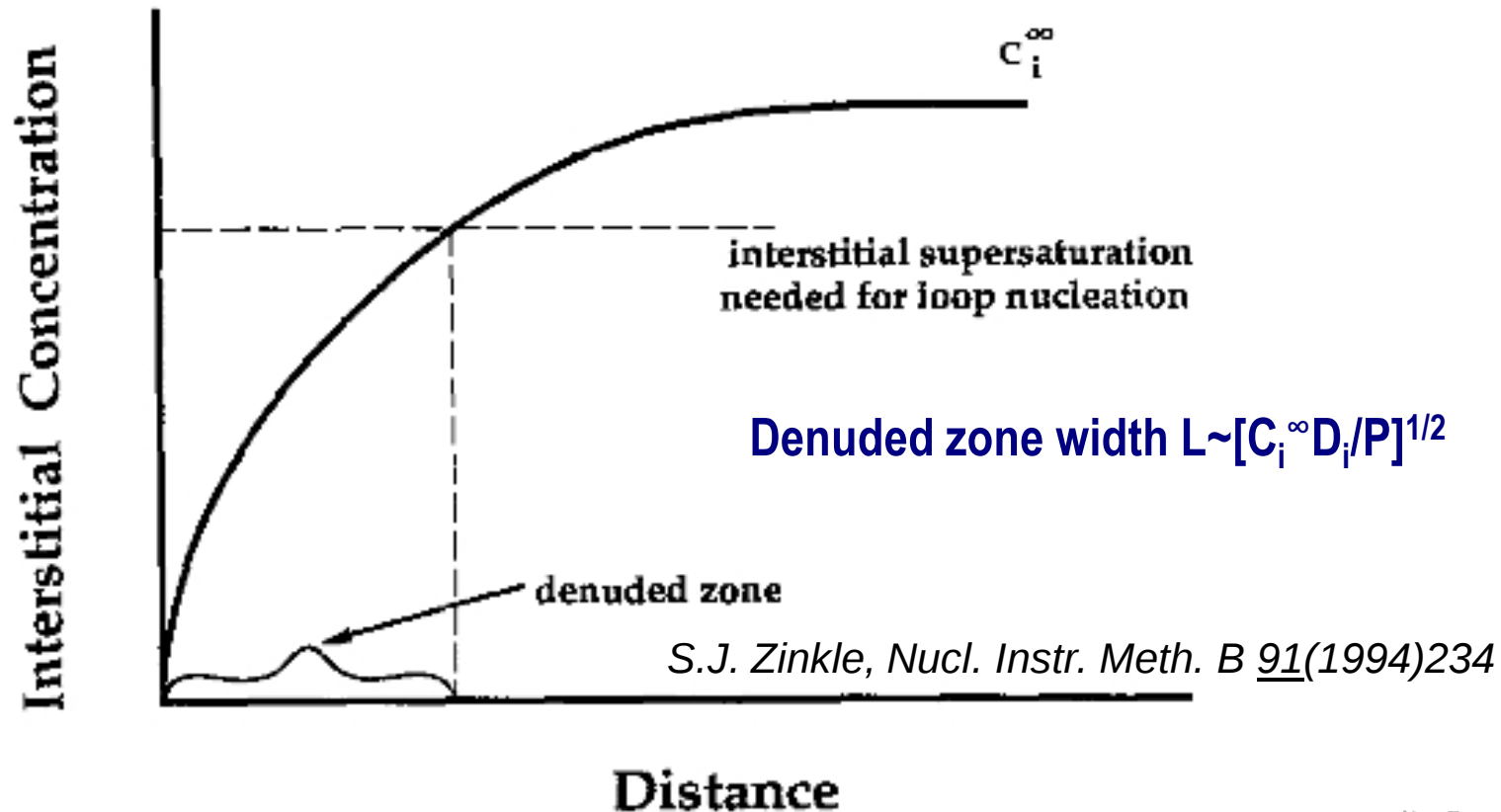
~5 dpa

Defect-free zones are predicted next to sinks (e.g., grain boundaries) due reduced point defect concentration

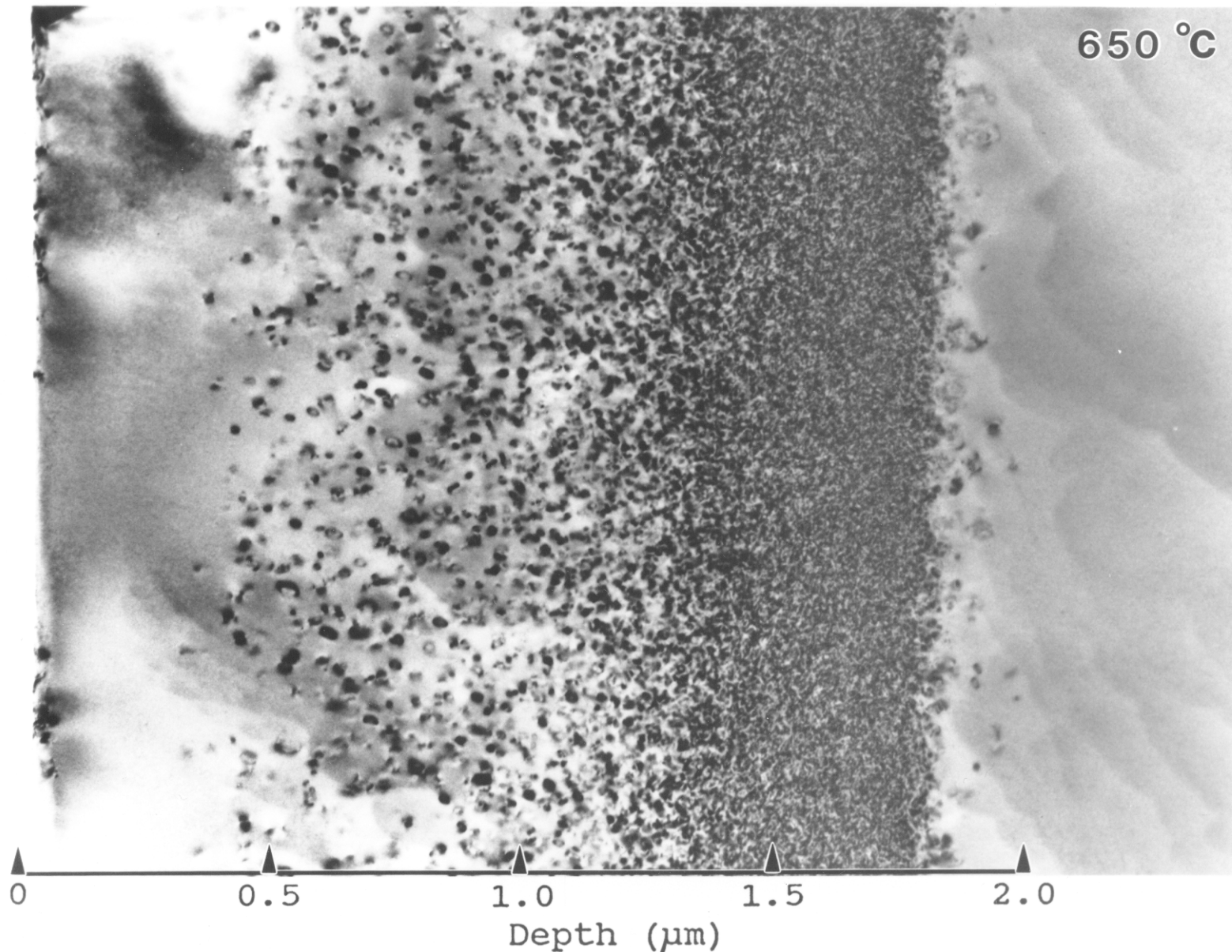
- Solve steady state rate eqns:

$$D_i \frac{d^2 C_i}{dx^2} - \alpha C_i C_v - D_i C_i C_s + P = 0$$

$$D_v \frac{d^2 C_v}{dx^2} - \alpha C_i C_v - D_v C_v C_s + P = 0$$

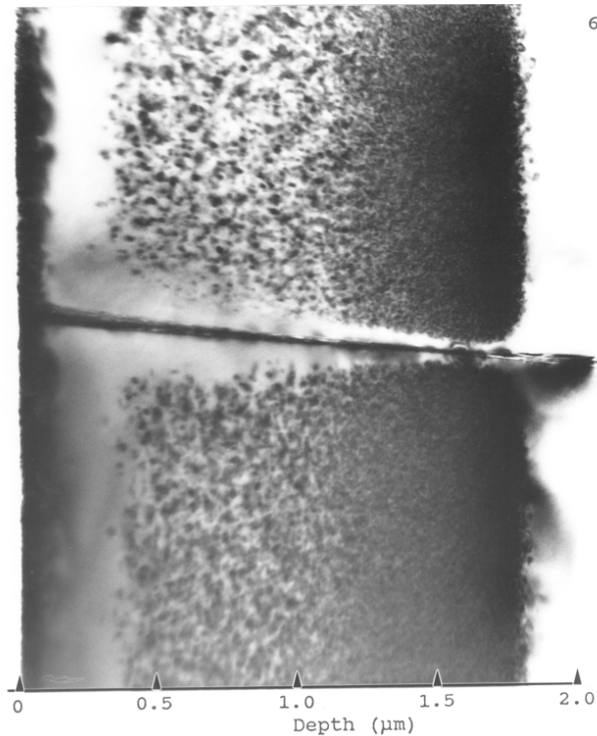


Depth dependent microstructure of MgAl_2O_4 irradiated with 2 MeV Al ions to a fluence of $4.6 \times 10^{20}/\text{m}^2$ at 650°C



Determination of interstitial migration energies in ceramics

Defect-free zones in ion-irradiated MgAl_2O_4



- Solve steady state rate eqns:

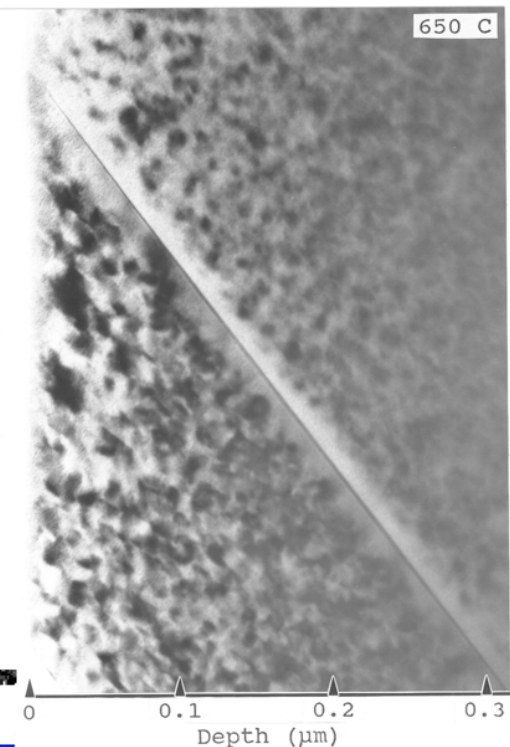
$$D_i \frac{d^2 C_i}{dx^2} - \alpha C_i C_v - D_i C_i C_s + P = 0$$

$$D_v \frac{d^2 C_v}{dx^2} - \alpha C_i C_v - D_v C_v C_s + P = 0$$

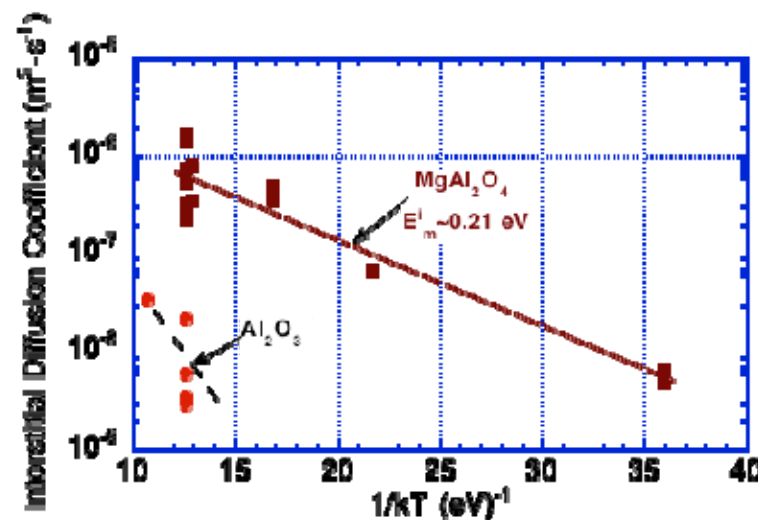
- For sink-dominant conditions ($C_s > 10^{14}/\text{m}^2$), the defect-free zone width is related to the diffusivity (D_i) and damage rate (P) by:

$$D_i = \frac{L P}{C_i^{\text{crit}} \sqrt{C_s}}$$

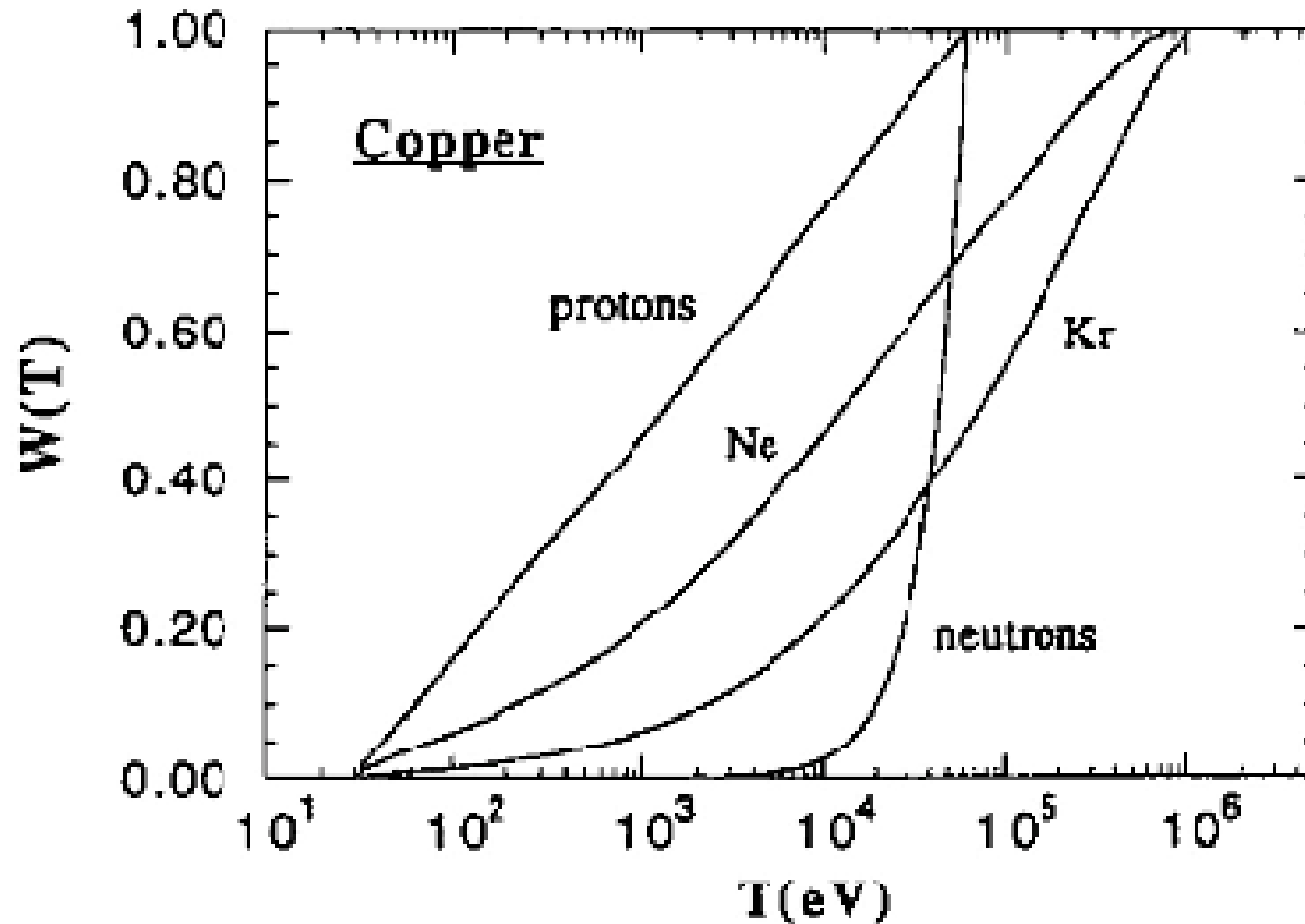
Defect-free grain boundary zones in ion-irradiated Al_2O_3



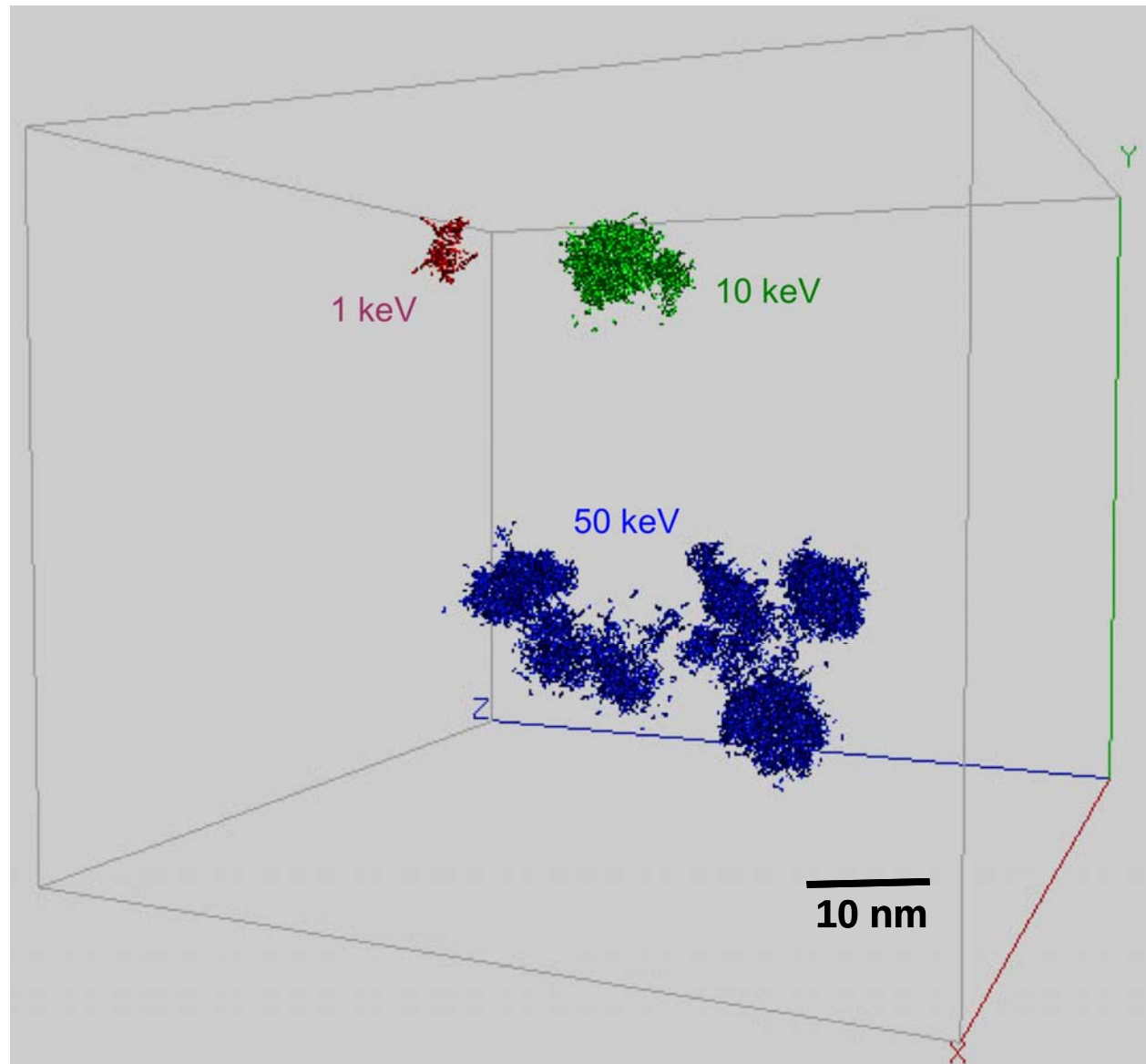
Interstitial Diffusion Coefficient in Ion Irradiated Oxides Determined From Defect-Free Zone Widths at Grain Boundaries



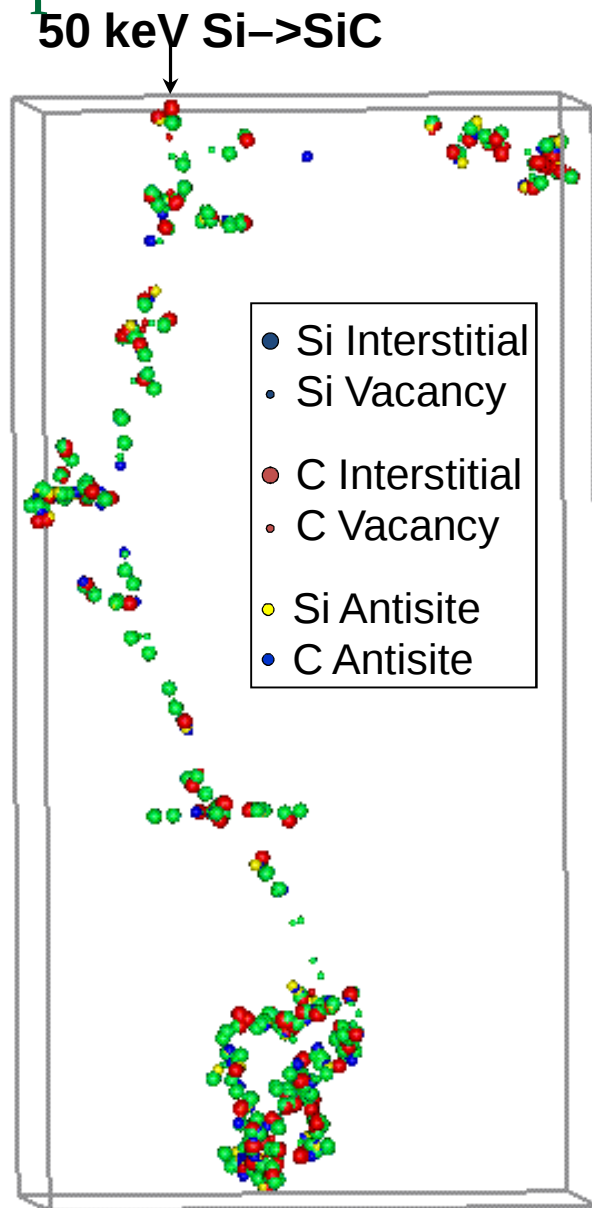
Weighted average recoil atom energy for 1 MeV particles in copper as a function of recoil energy (T)



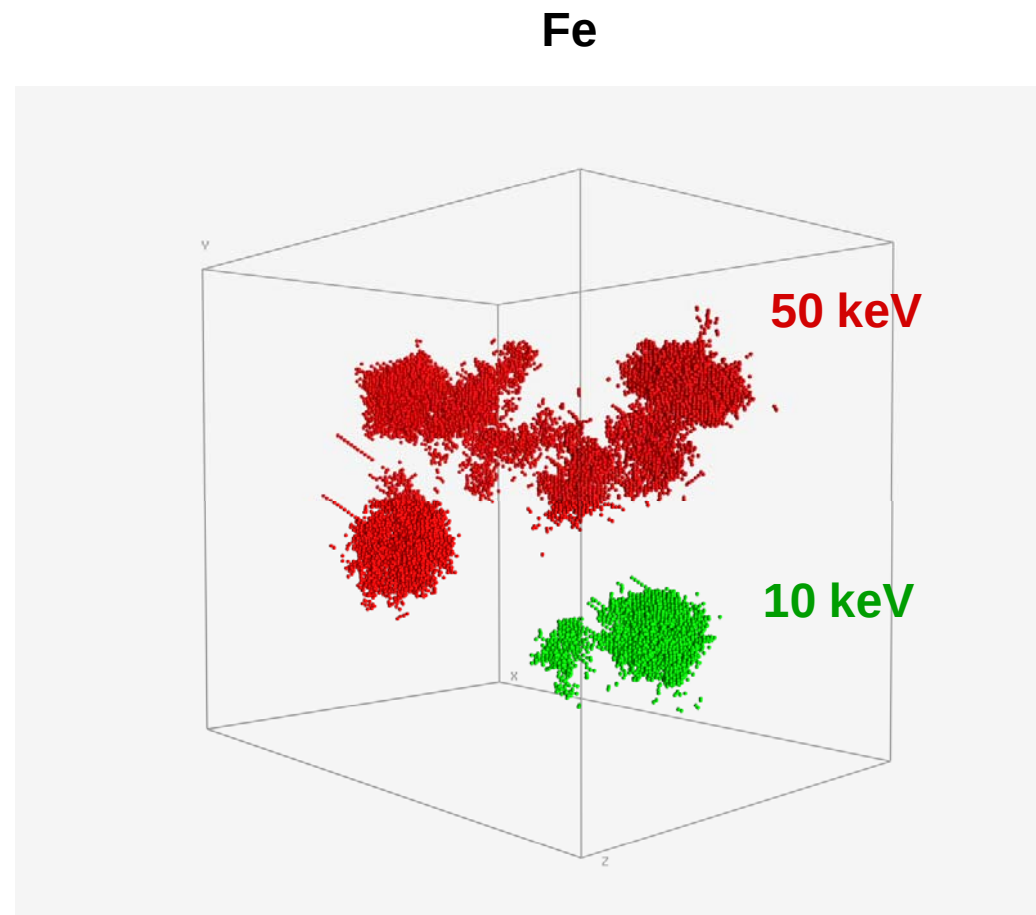
Comparison of molecular dynamics simulations of 1-50 keV PKA displacement cascades in iron



Displacement cascades in ceramics such as SiC are much less compact than in medium-Z metals

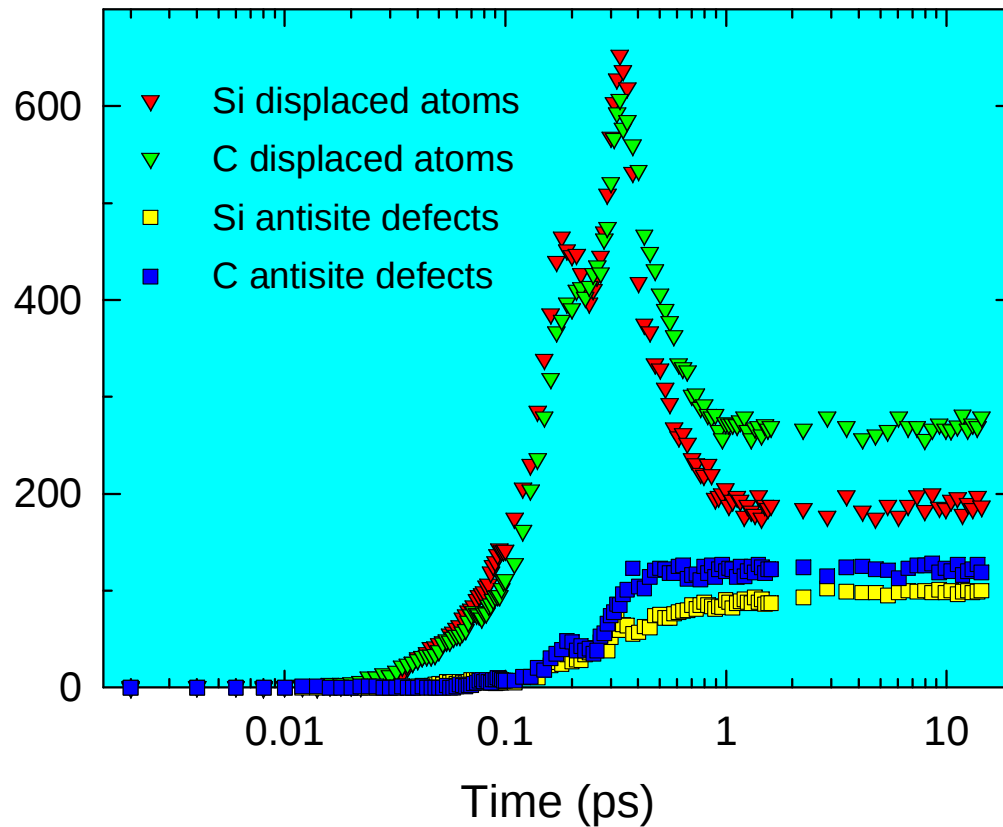


F Gao & WJ Weber *Phys. Rev. B* 63 (2000) 054101



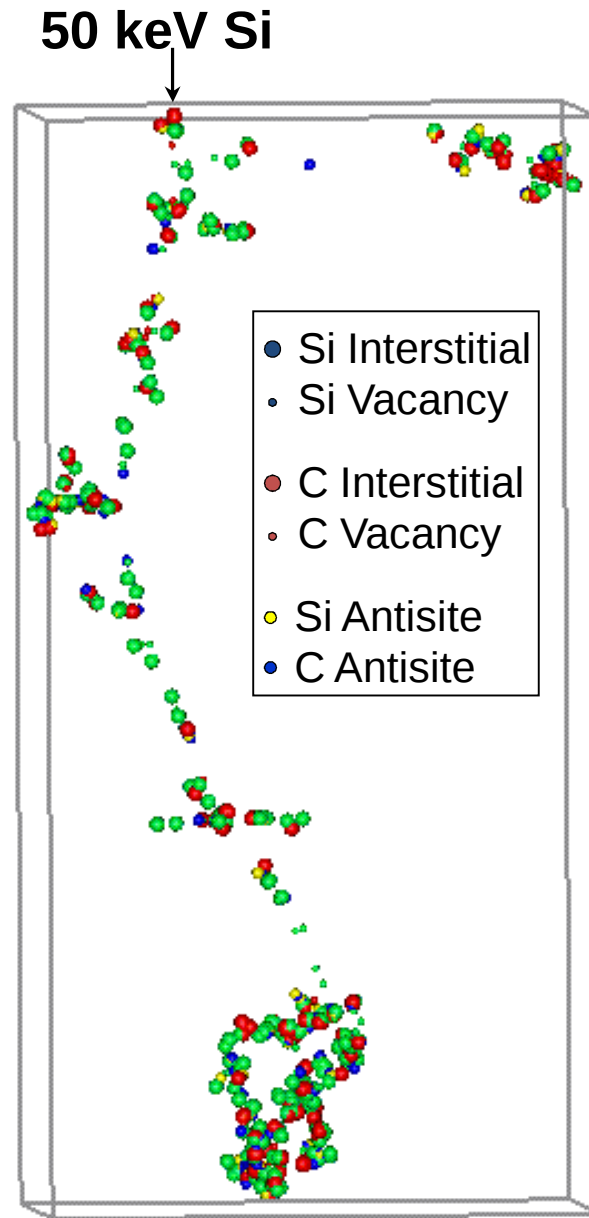
R.E. Stoller *J.Nucl. Mater.* 276 (2000) 22

MD Simulation of 50 keV Si Cascade in 3C-SiC



Time dependence and spatial distribution of defect production in a 50 keV Si cascade

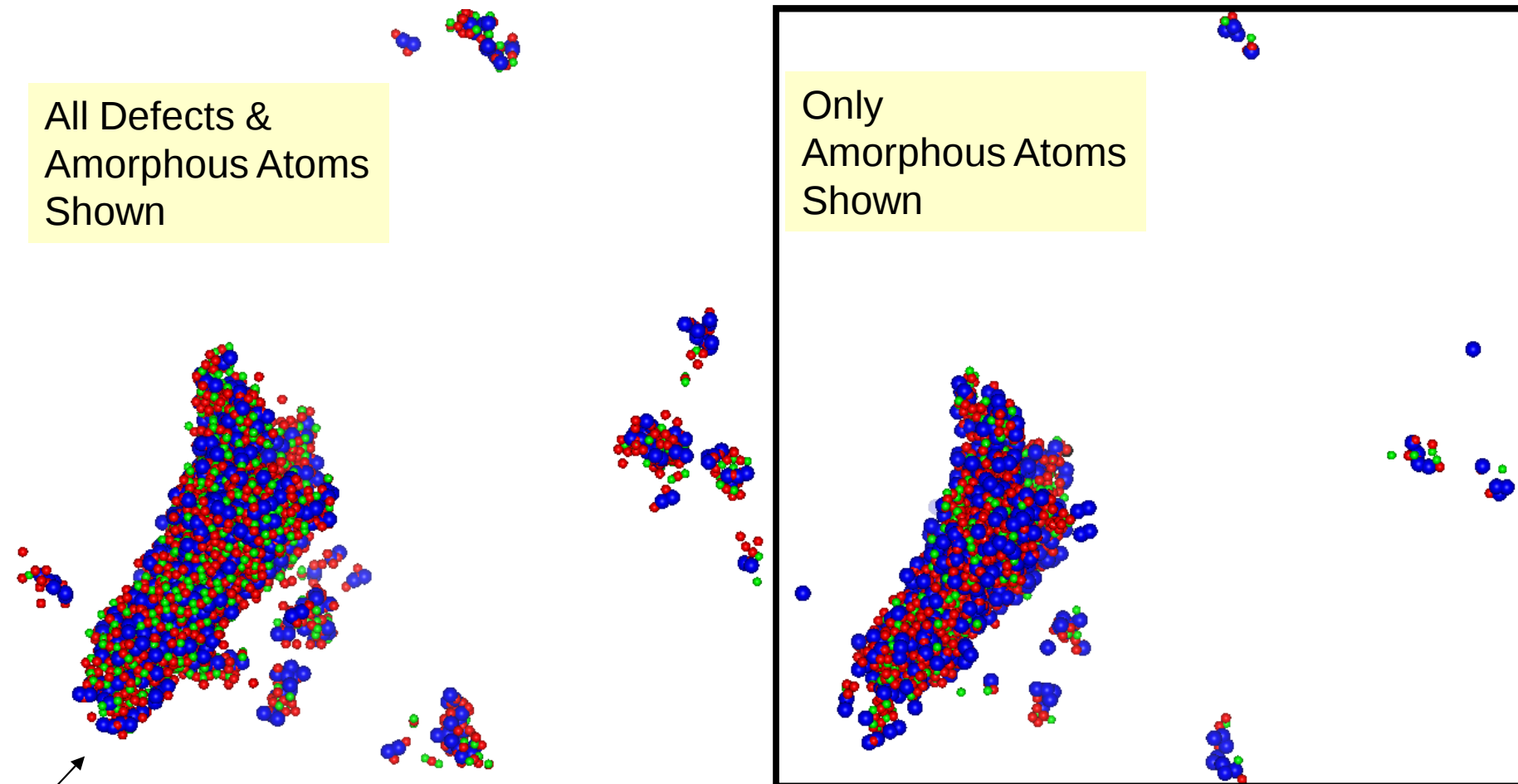
F Gao & WJ Weber
Physical Review B 63 (2000) 054101



Defects & Amorphous Atoms for 30 keV U in Zircon

All Defects &
Amorphous Atoms
Shown

Only
Amorphous Atoms
Shown



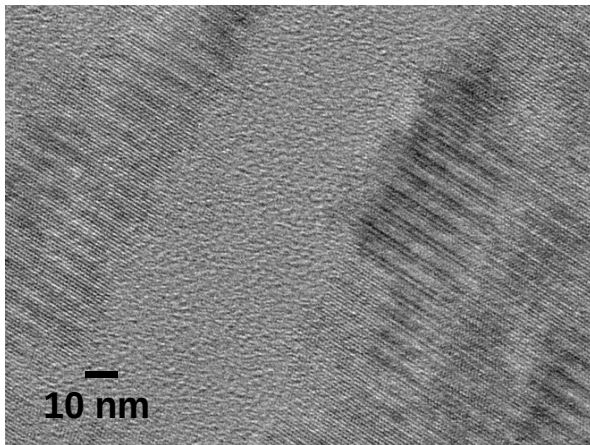
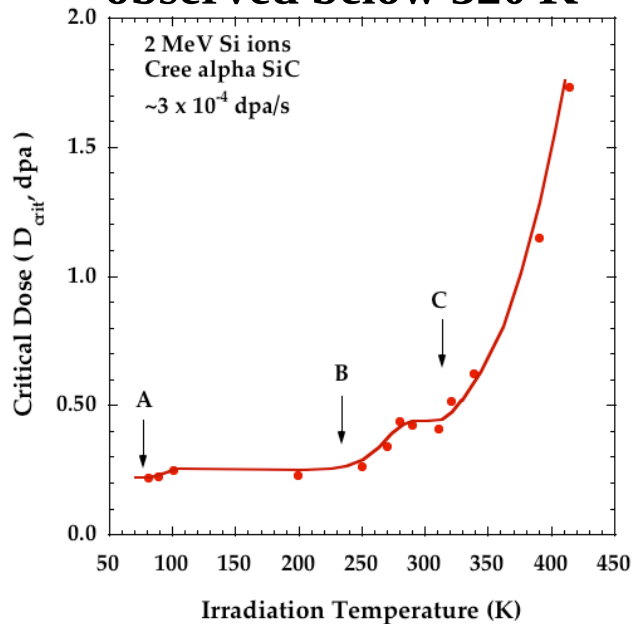
U initial position

- 1.1 million atom simulation
- Zr, Si and O are shown
- Core is Si rich; periphery is Zr rich

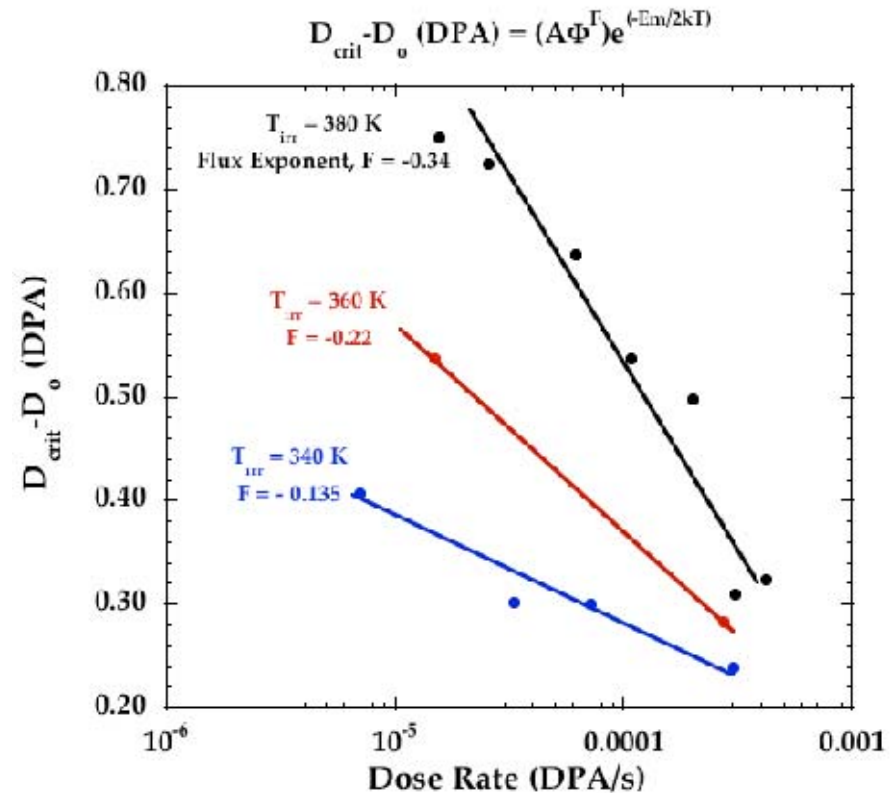
W.J. Weber, et al.

SiC Amorphization

3 recovery substages are observed below 320 K

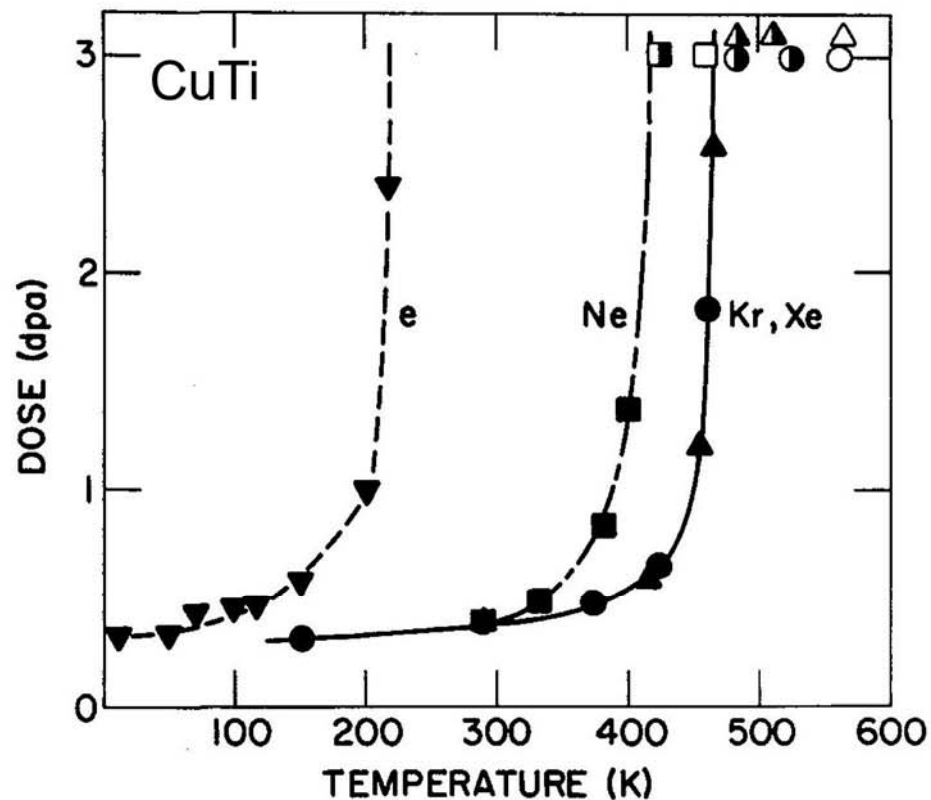


Analysis of flux dependence shows recovery substages are not associated with long range point defect migration ($F < 0.5$ up to 380 K)

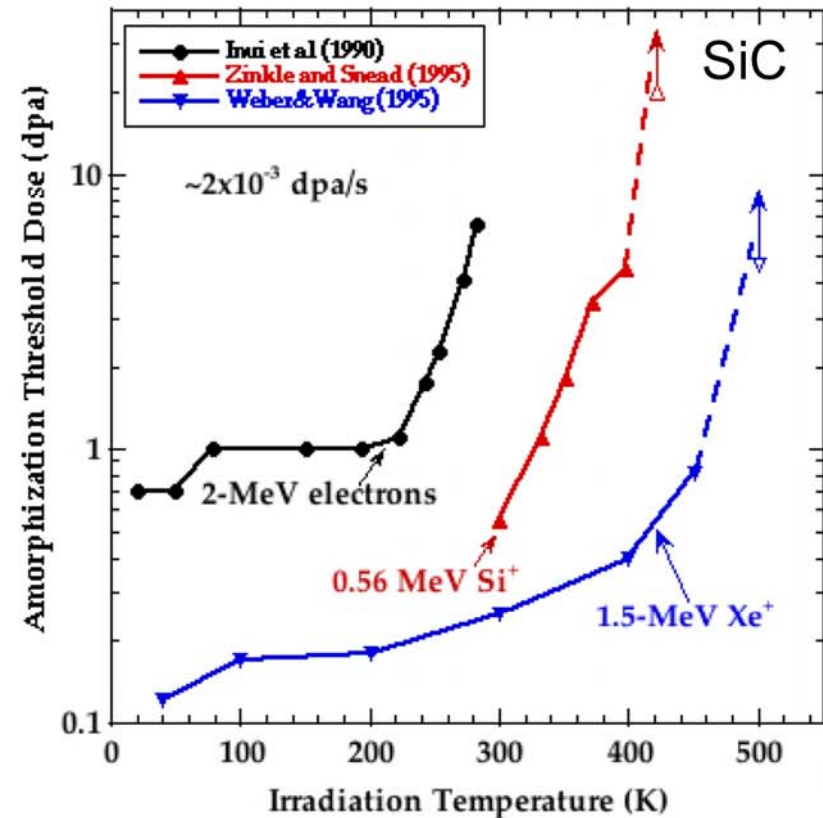


➡ Implies that both vacancies and interstitials are immobile in SiC up to 100°C (interstitials are mobile in many other ceramics at room temperature)

Effect of irradiating particle (PKA energy) on the temperature-dependent dose for amorphization



J. Koike et al., Appl. Phys. Lett. 59 (1991) 2515

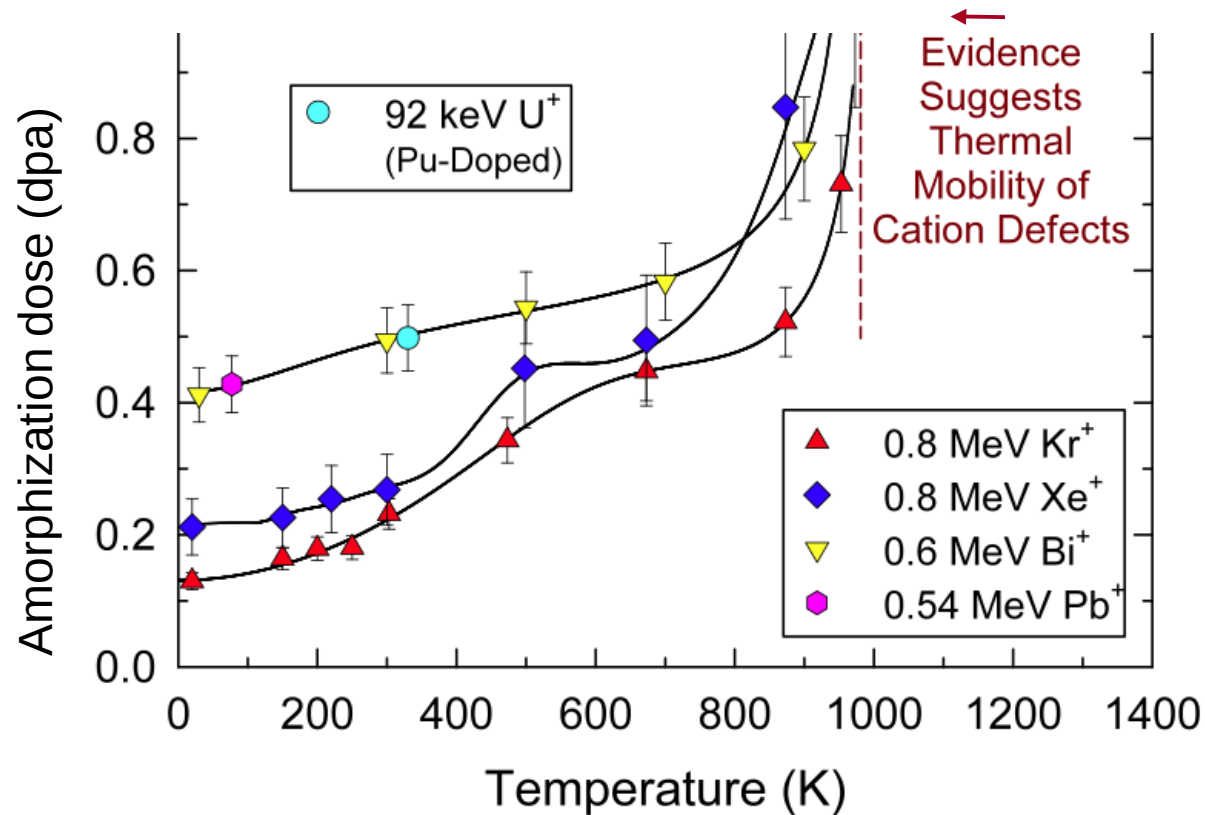


Zinkle & Snead, Nucl. Instr. Meth. B 116 (1996) 92

Note: there are also numerous cases where PKA energy has a weak effect on amorphization dose (degree of sensitivity is linked to amorphization mechanisms)

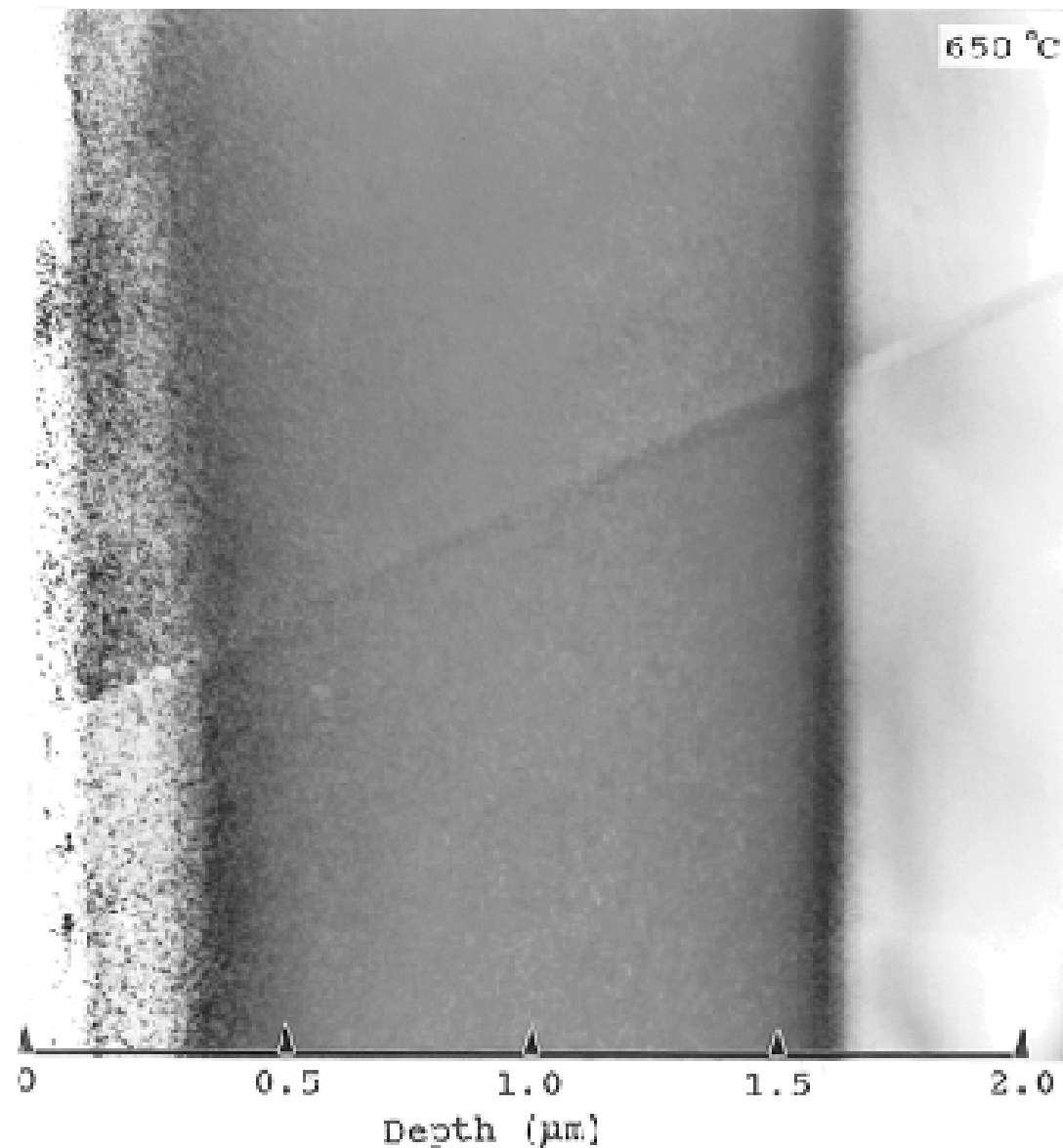
ZrSiO_4 : Temperature Dependence

Good Agreement Between Heavy-Ion (Pb and Bi) Data and ^{238}Pu Data

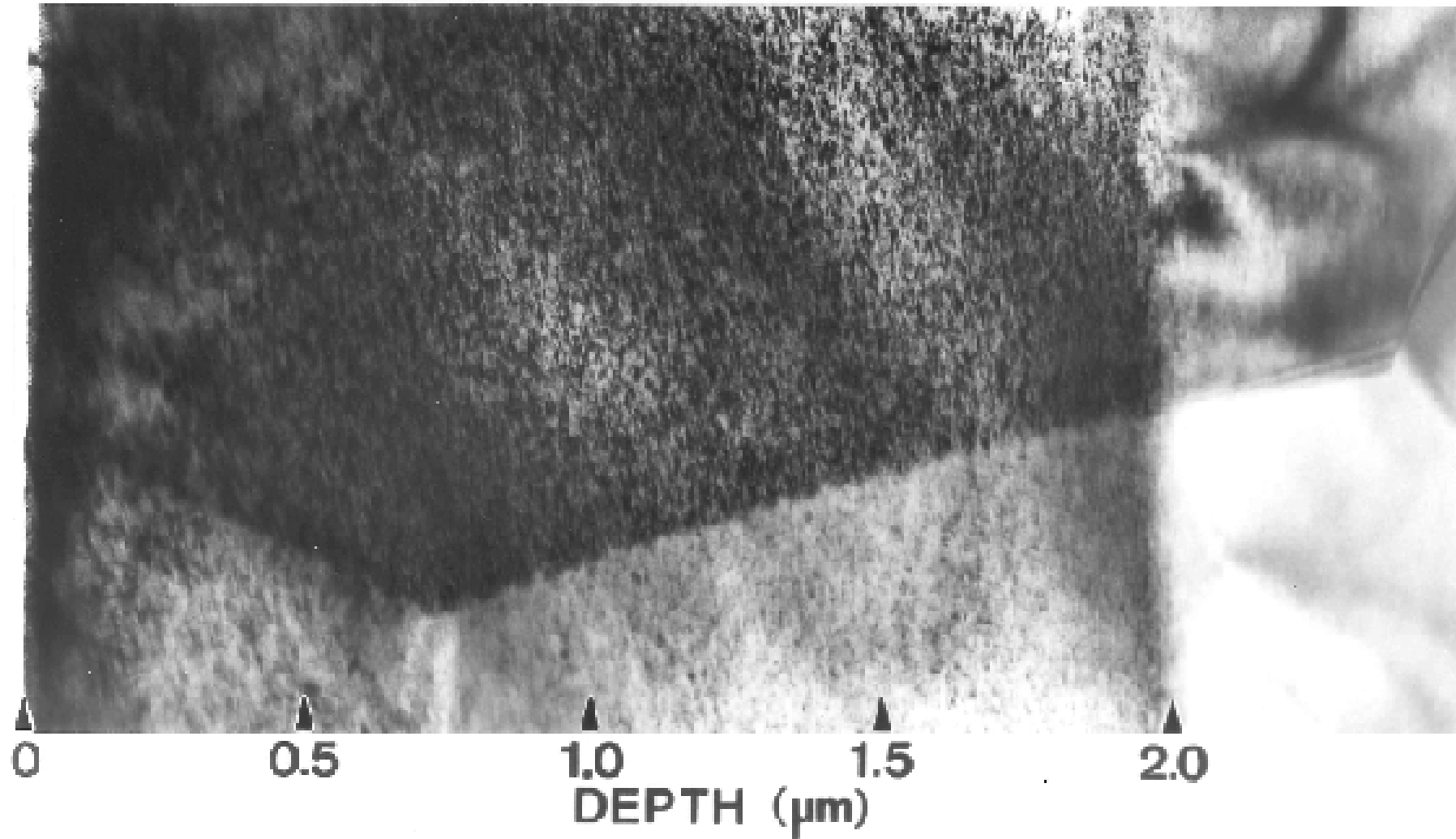


(T_c is Independent of Irradiating Ion Mass $\rightarrow$ Thermal Recovery Process)

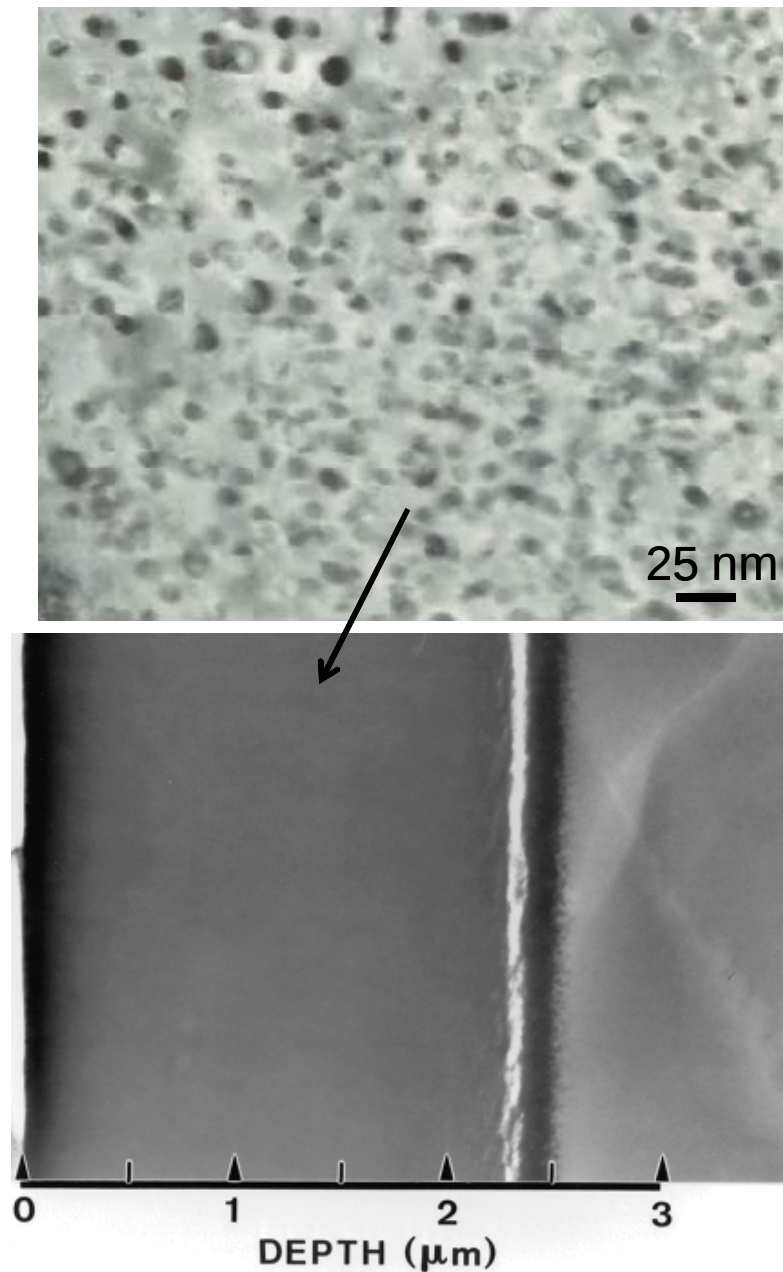
Cross-section microstructure of Al_2O_3 irradiated with 2 MeV Al ions at 650 C to a fluence of $9 \times 10^{20}/\text{m}^2$



Cross-section microstructure of Al_2O_3 irradiated with 3 MeV C ions at 420 C to 18 dpa

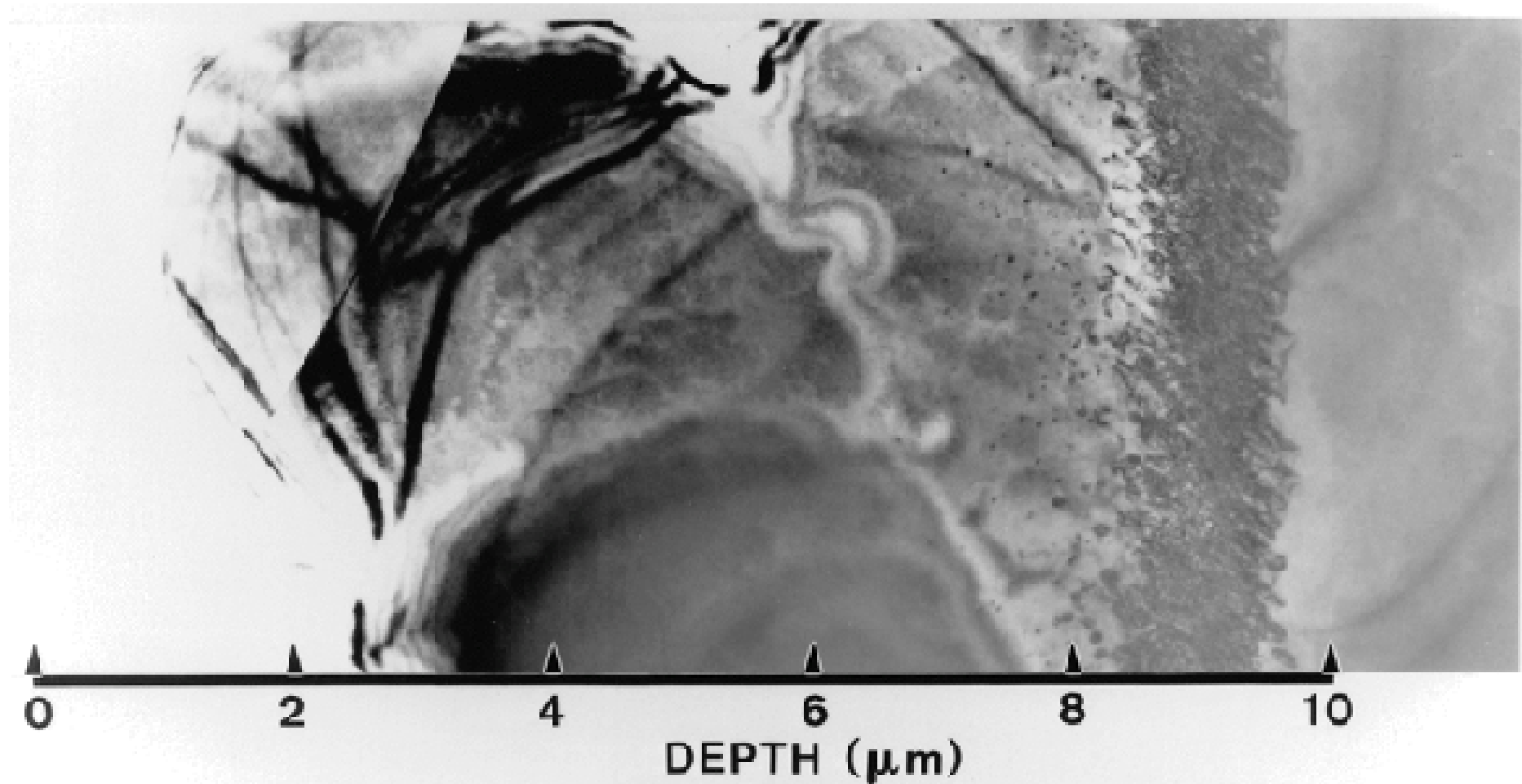


Cross-section microstructure of Al_2O_3 irradiated with 1 MeV He ions at 650 C to a fluence of $1 \times 10^{22}/\text{m}^2$



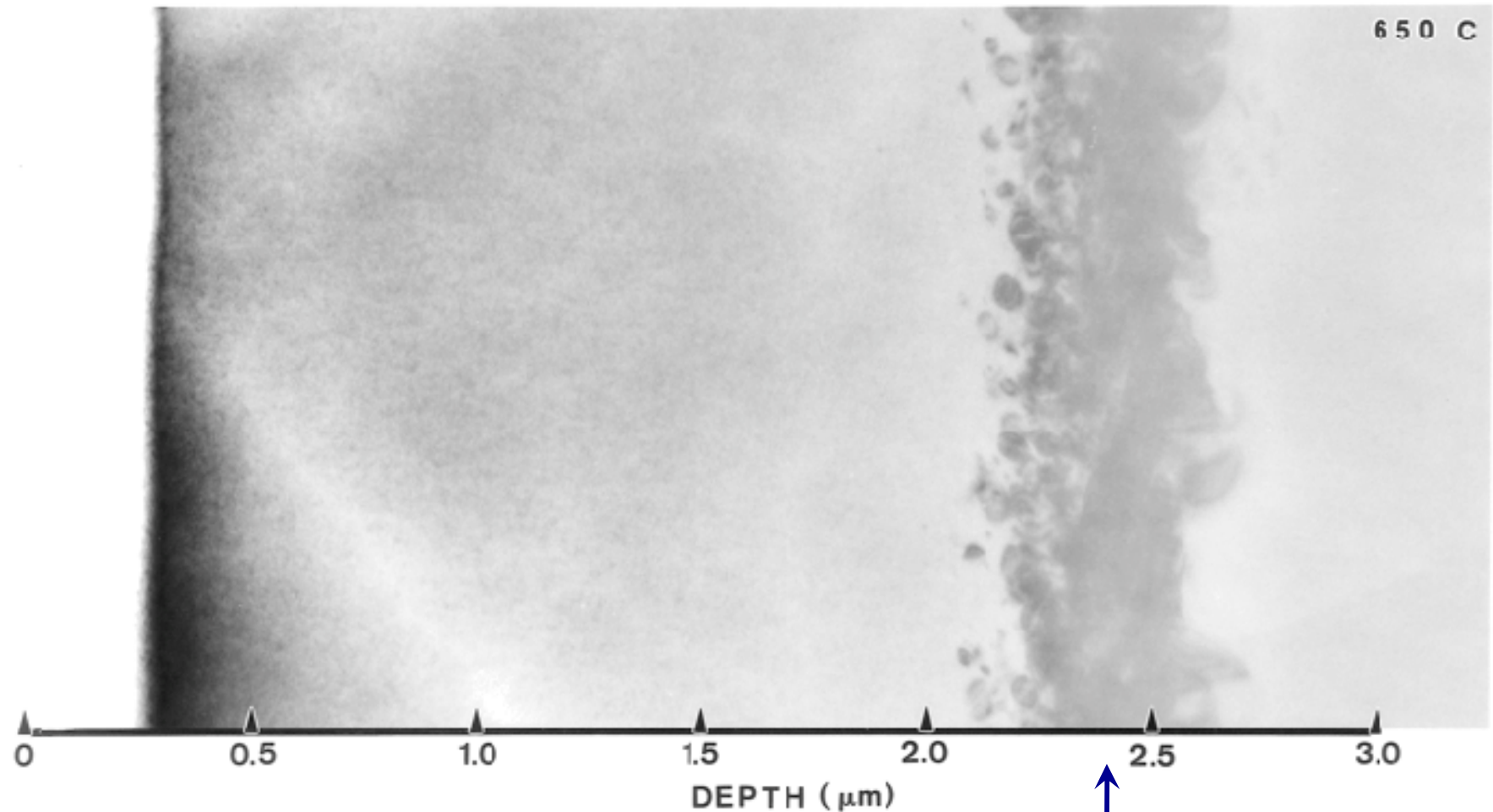
S.J. Zinkle, Nucl. Instrum.
Meth. B (2012) in press

Cross-section microstructure of Al_2O_3 irradiated with 1 MeV H ions at 650 C to a fluence of $1.7 \times 10^{22}/\text{m}^2$



3 dpa, 60at.%H at peak;
0.03 dpa at 0.5 μm

Cross-section TEM microstructure of 1 MeV He ion irradiated MgAl_2O_4 at 650°C (1×10^{21} He/m²)

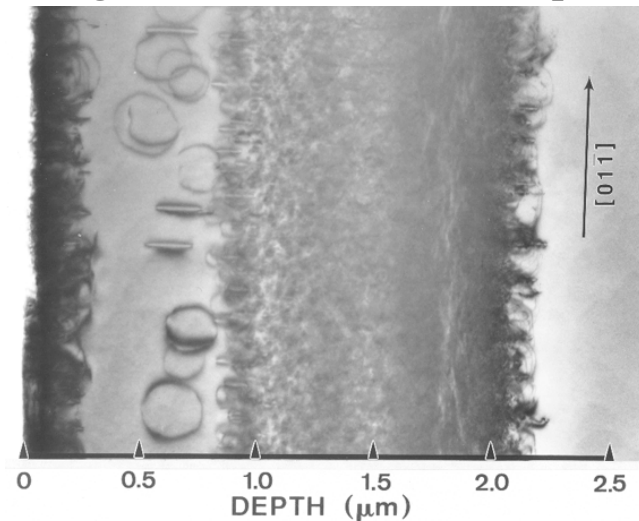
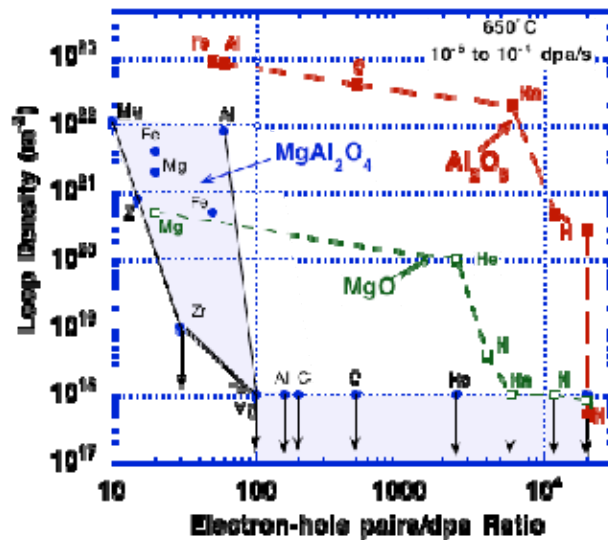


2.44 μm

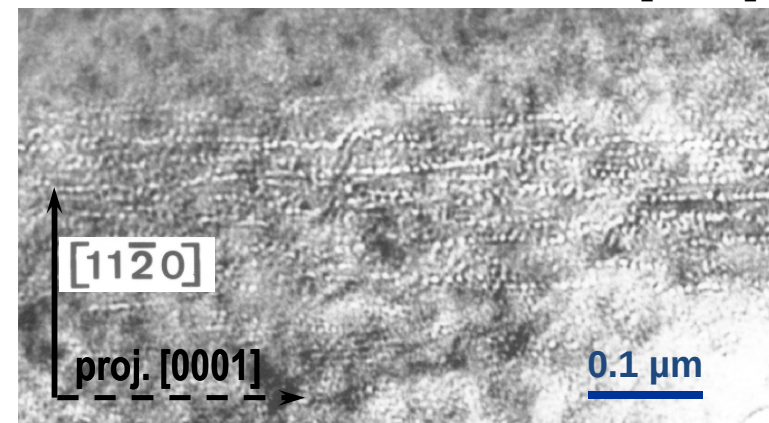
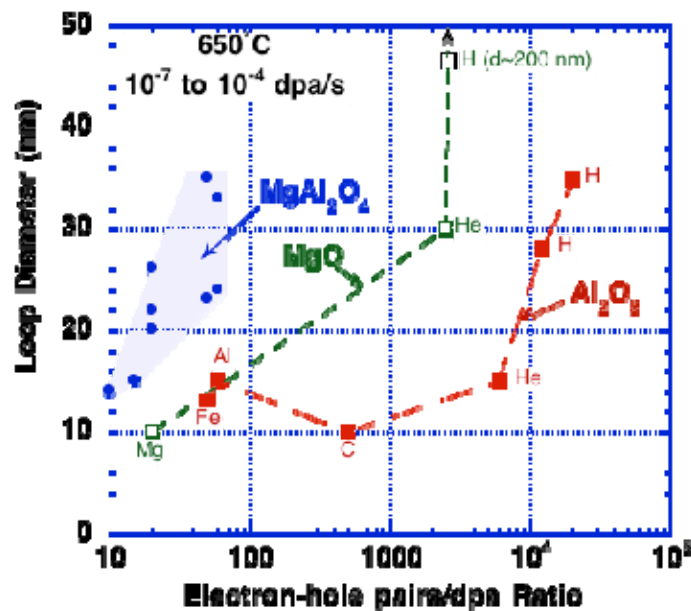
2.1 dpa, 5 at%He
at peak

Investigation of ionization-induced diffusion in ceramics

Large interstitial loops in MgAl_2O_4 ion-irradiated at 25°C for regions with >100 eln.-hole pairs per dpa



Aligned cavities in Al_2O_3 ion-irradiated at 25°C (Al/O/He ion irradiation, >500 eln.-hole pairs per dpa)

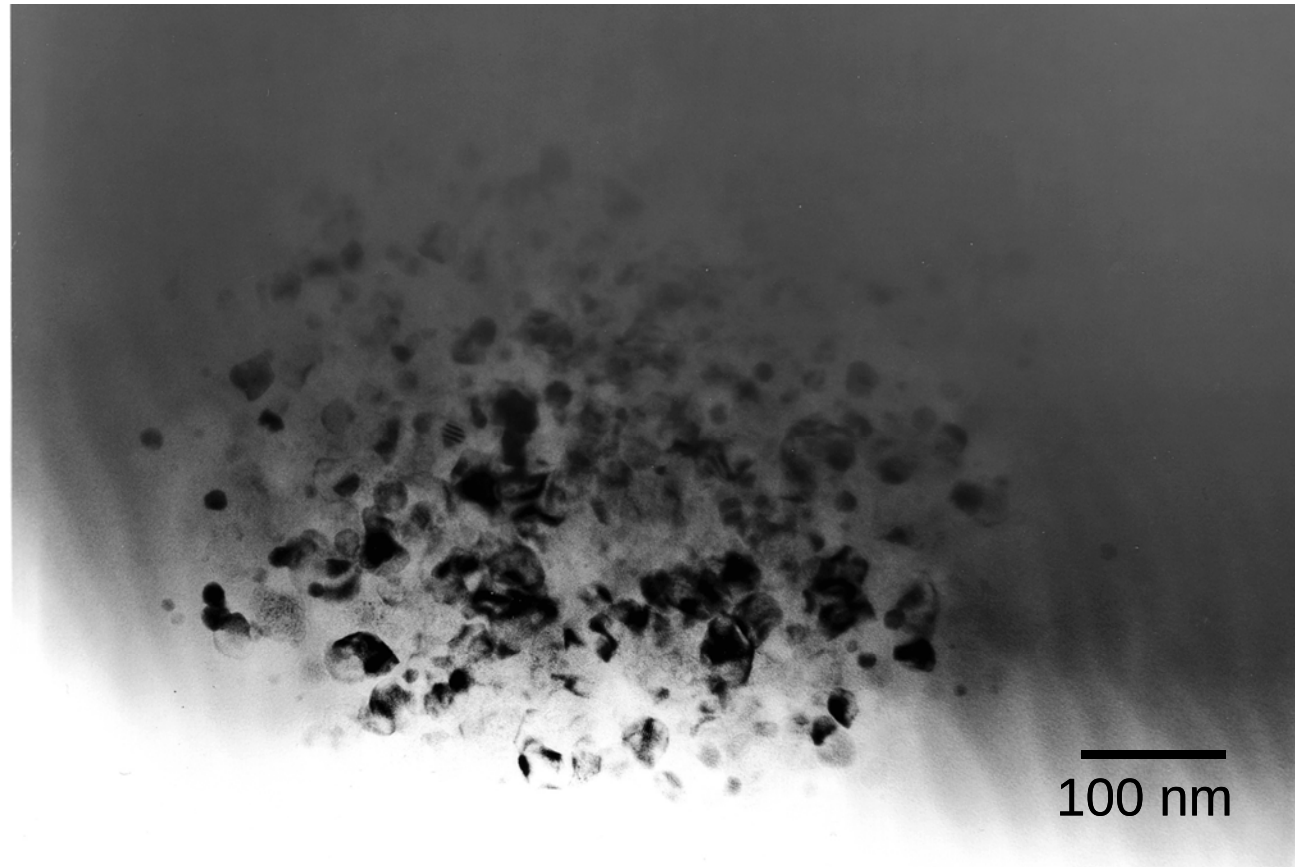


Ionizing Radiation can induce myriad effects in ceramics

- Defect annealing and coalescence (ionization-induced diffusion)
 - **Athermal defect migration is possible in some materials**
- Defect production
 - **Radiolysis (SiO_2 , alkali halides)**
 - **Ion track damage (“swift heavy ions”)**

Ionizing Radiation can induce recrystallization in amorphous ceramics

- 120 keV electron (subthreshold displacement energy) illumination of MgAl_2O_4 (amorphized by swift heavy ion irradiation)



Max energy transfer = 11 eV (Al), 12 eV (Mg), 18 eV (O)

Swift heavy ions ($S_e > 1-10$ keV/nm) can introduce new physical phenomena in metals compared to conventional particle irradiations

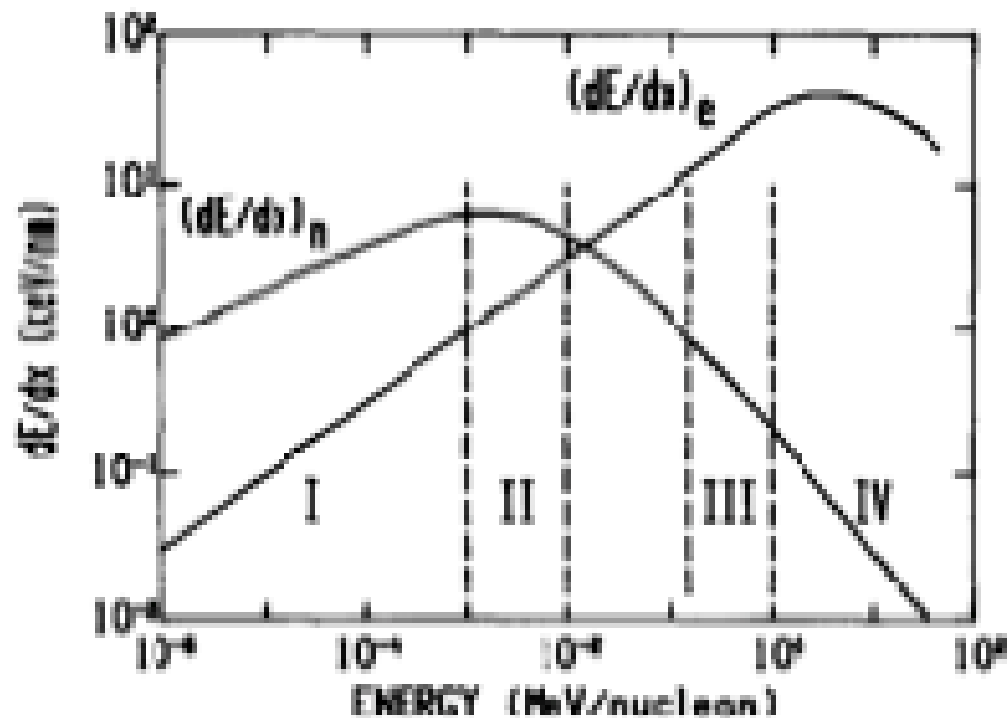
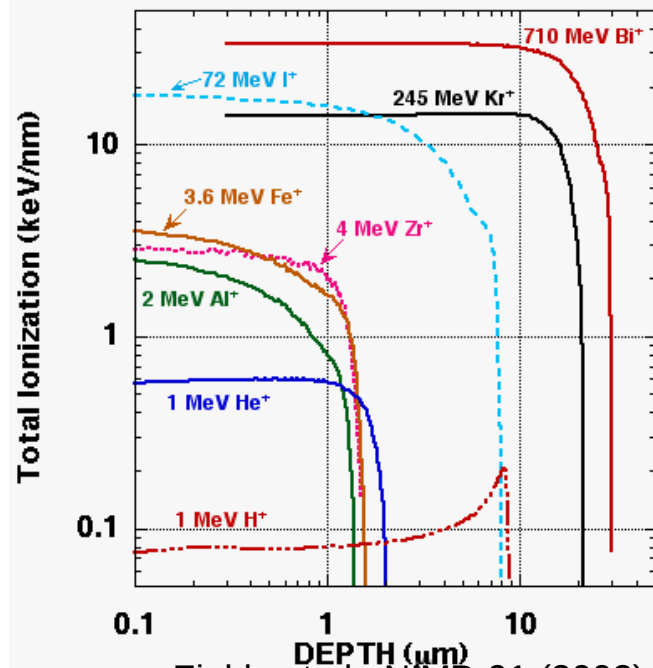


Fig. 1. Electronic and nuclear stopping powers of xenon ions in an iron target as a function of the incident ion energy:

Swift heavy ions ($S_e > 1-10 \text{ keV/nm}$) can introduce new radiation effects phenomena

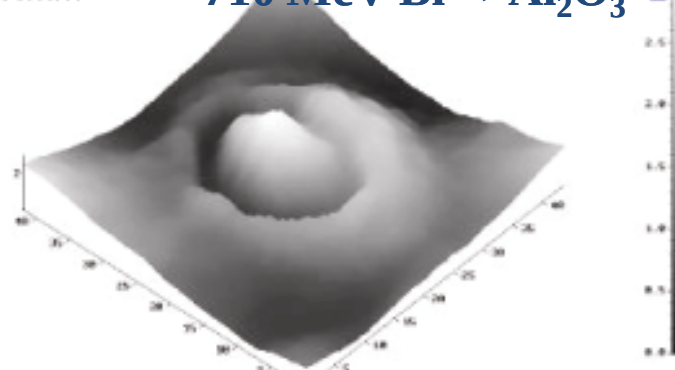
ELECTRONIC STOPPING POWERS IN ALUMINA



Zinkle et al., NIMB 91 (2002) 758

$(dE/dx)_{\text{ion}}$
41 keV/nm

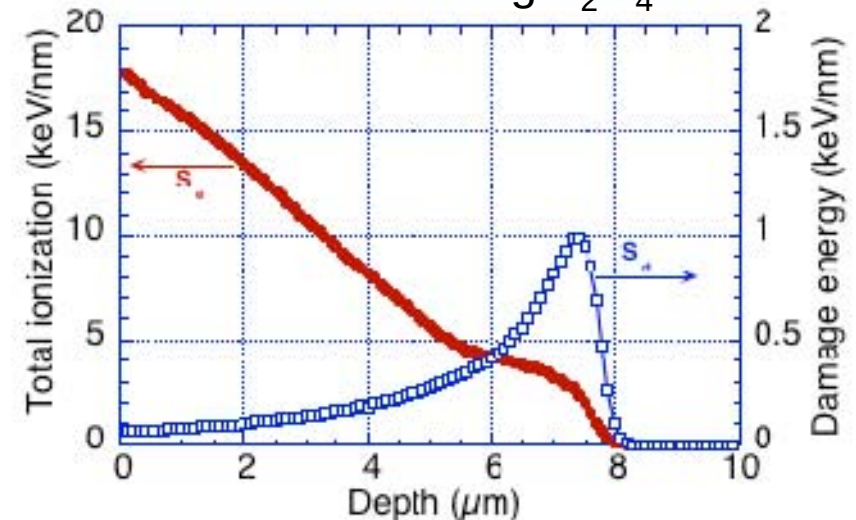
710 MeV Bi $\rightarrow$ Al₂O₃



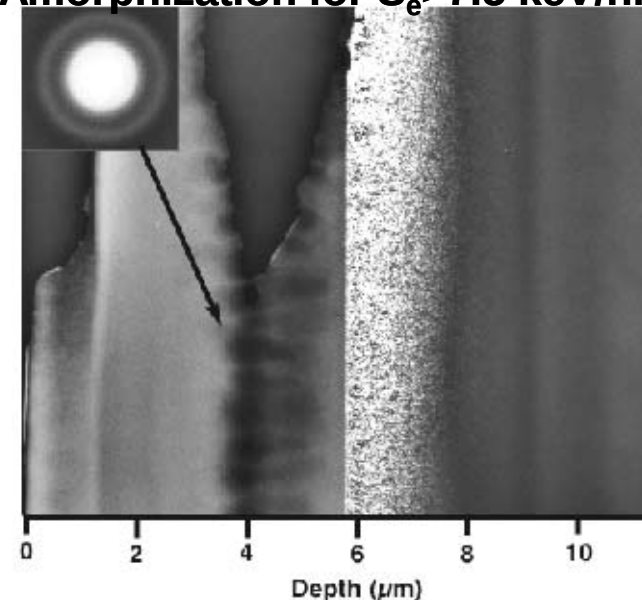
39

Skuratov et al., Rad. Meas. 34 (2001) 571

72 MeV I⁺ $\rightarrow$ MgAl₂O₄



Amorphization for $S_e > 7.5 \text{ keV/nm}$



Zinkle et al., MRS symp proc 540 (1999) p. 299

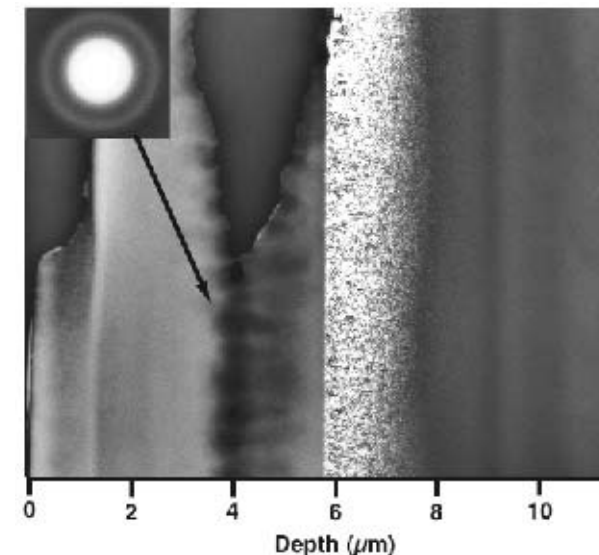
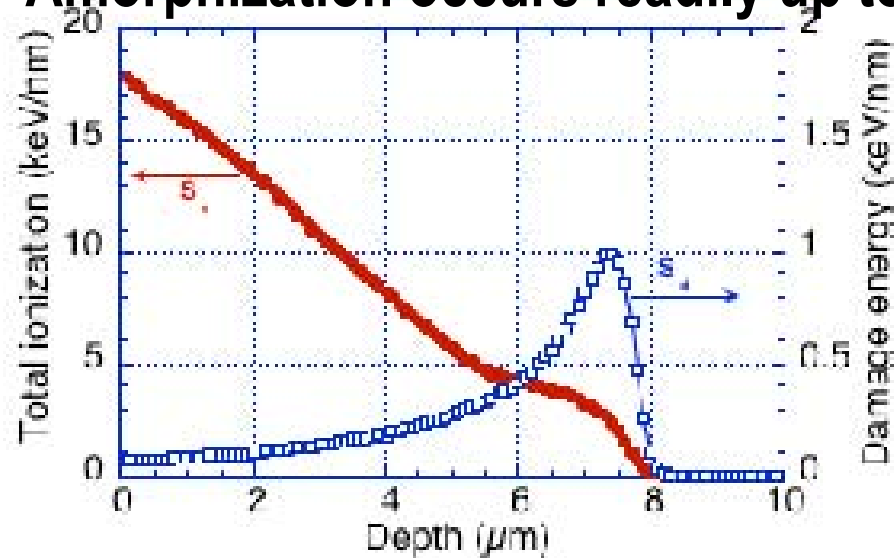
The high electronic stopping powers associated with fission fragment recoil ions can produce pronounced effects

- MgAl_2O_4 irradiated with 72 MeV I^+ ions experiences a crystalline phase change and then amorphization when $(dE/dx)_e > 8 \text{ keV/nm}$

- Volumetric expansion $\Delta V/V \sim 35\%$ due to amorphization will cause severe stresses and cracking

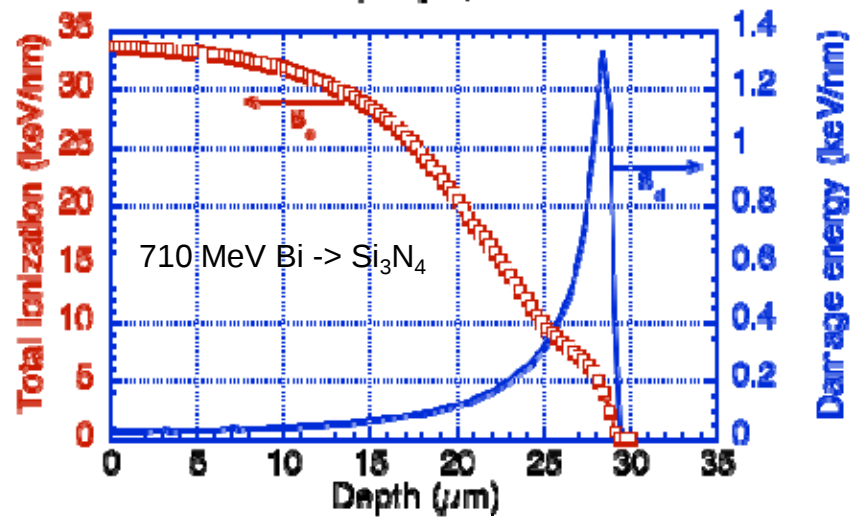
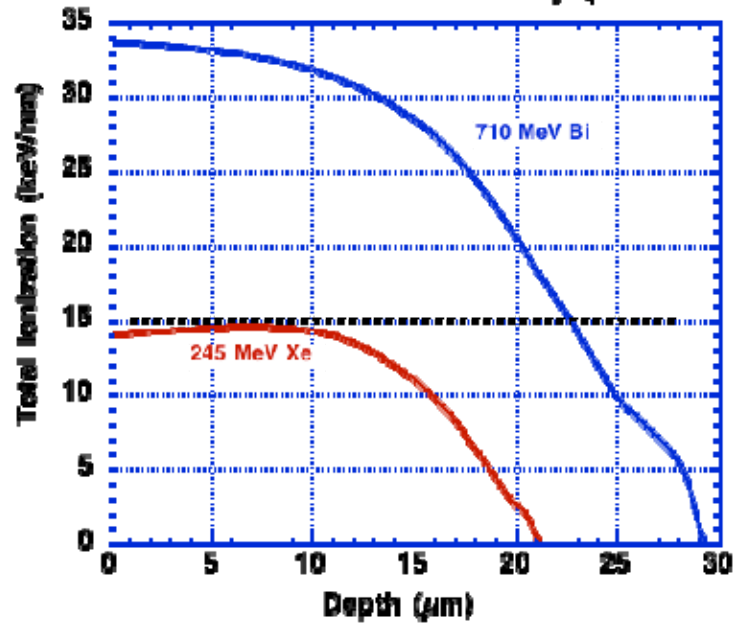
- Amorphization occurs readily up to 500°C

72 MeV $\text{I}^+ \rightarrow \text{MgAl}_2\text{O}_4, 1 \times 10^{16}/\text{cm}^2$



Zinkle, Matzke and Skuratov, MRS Symp. Proc. Vol. 540 (1999), pp. 299-304

Comparison of Ionization Stopping Powers
for Swift Heavy Ions in Si_3N_4



710 MeV Bi $\rightarrow$ Si_3N_4



Summary of threshold ionizing radiation levels for defect production in ceramics

Material	Thermal conductivity (W/m-K)	Threshold $dE/dx)_e$ for ion track damage
$MgAl_2O_4$	20	8 keV/nm
$\beta-Si_3N_4$	29	15 keV/nm
Al_2O_3	32	~20 keV/nm
AlN	177	>34 keV/nm
SiC	350	>34 keV/nm
U_3Si		19 keV/nm [Hou 2003]
UO_2		22-29 keV/nm [Matzke 2000]

- Velocity effects also need to be considered (low velocity ions are more effective at inducing damage for a given $dE/dx)_e$)
- Threshold $dE/dx)_e$ is higher than the ionizing radiation fields anticipated in fission or fusion reactors
- Studies on effect of radiation-induced thermal conductivity degradation on threshold dE/dx for track formation are in progress

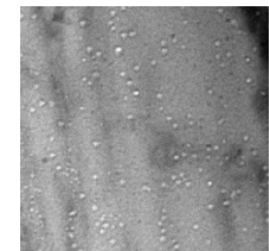
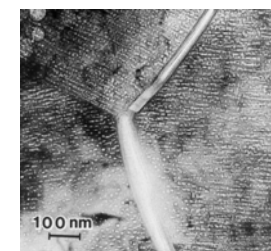
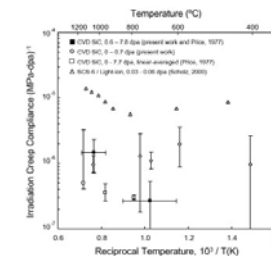
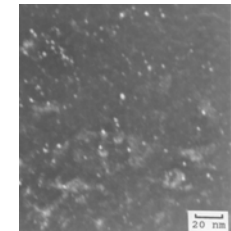
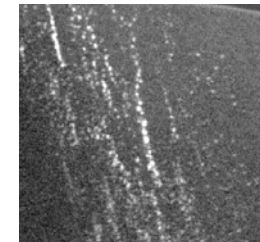
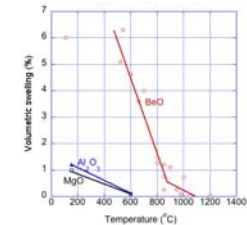
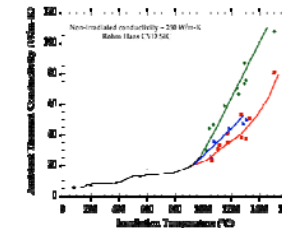
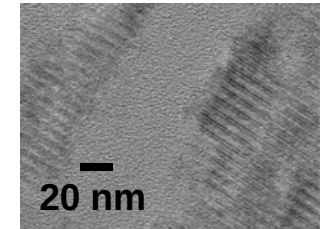
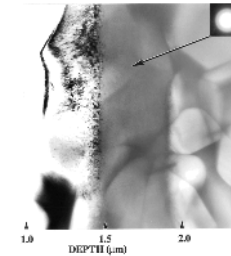
42 — radiation-induced degradation of K_{th} may cause reduction in threshold $dE/dx)_e$
 Managed by OR-Battelle for the U.S. Department of Energy

Conclusions

- Irradiation temperature has a pronounced effect on microstructural evolution
 - Important regimes include onset temperatures for interstitial and vacancy defects
- Dose dependence of microstructural evolution is generally more complex at elevated temperatures
 - Saturation often occurs at 0.1-0.5 dpa at low temperatures
- Implanted ions can exert significant influence on the microstructural evolution (e.g., amorphization, precipitation)
- Effect of irradiation spectrum can be complex
 - Primary knock-on atom effects
 - Ionizing radiation effects
 - Swift heavy ion effects (brief introduction)

Radiation Damage can Produce Large Changes in Ceramic Materials

- Amorphization and disordering ($<0.2 T_M$, >0.1 dpa)
- Thermal conductivity degradation and defect cluster swelling ($<0.35 T_M$, >0.01 dpa)
- Phase instabilities from radiation-induced precipitation ($0.3-0.6 T_M$, >10 dpa)
- Irradiation creep ($<0.45 T_M$, >10 dpa)
- Volumetric swelling from void formation ($0.3-0.6 T_M$, >10 dpa)



Depth dependent microstructure of MgAl_2O_4 irradiated with 2 MeV Al ions to a fluence of $3.7 \times 10^{21}/\text{m}^2$ at 650°C

